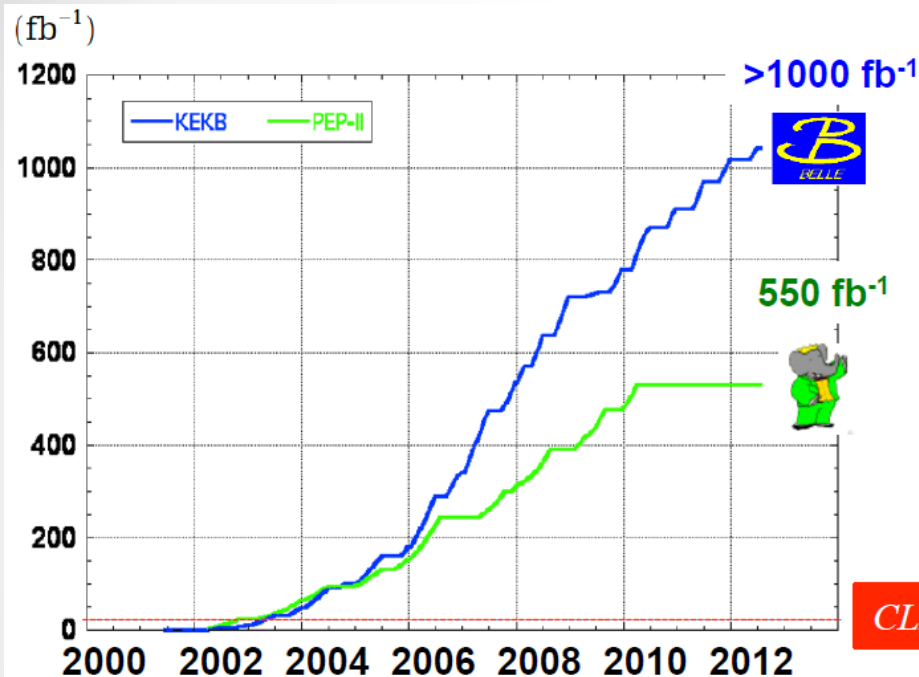


Development and Construction of the TOP counter for the Belle II Experiment

Tomokatsu Hayakawa
(KMI現象解析研究センター・実験観測機器開発室)



Belle → Belle II

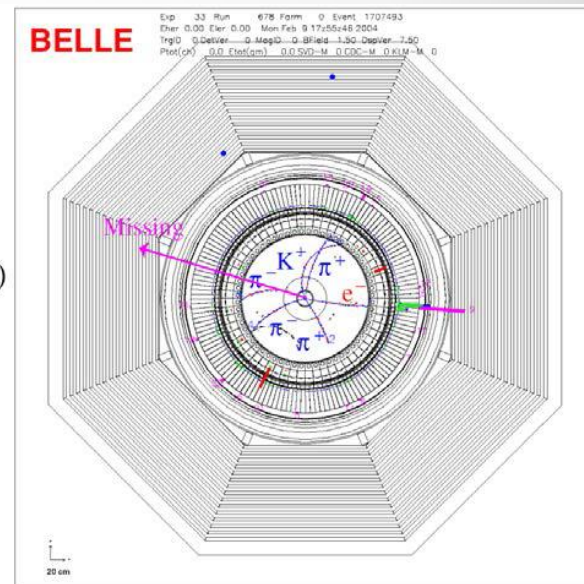
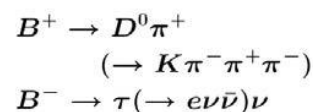


Channel	Belle	BaBar	Belle II (per year)
$B\bar{B}$	7.7×10^8	4.8×10^8	1.1×10^{10}
$B_s^{(*)} \bar{B}_s^{(*)}$	7.0×10^6	—	6.0×10^8
$\Upsilon(1S)$	1.0×10^8	—	1.8×10^{11}
$\Upsilon(2S)$	1.7×10^8	0.9×10^7	7.0×10^{10}
$\Upsilon(3S)$	1.0×10^7	1.0×10^8	3.7×10^{10}
$\Upsilon(5S)$	3.6×10^7	—	3.0×10^9
$\tau\tau$	1.0×10^9	0.6×10^9	1.0×10^{10}

- Belle II Goal : 40 x present = 4×10^{10} BB pairs
 - Accelerator upgrade (➔ SuperKEKB): Higher luminosity (x~40)
 - Detector upgrade (➔ Belle II): Precise measurement



B factories in the LHC era



Unique capabilities of B factories:

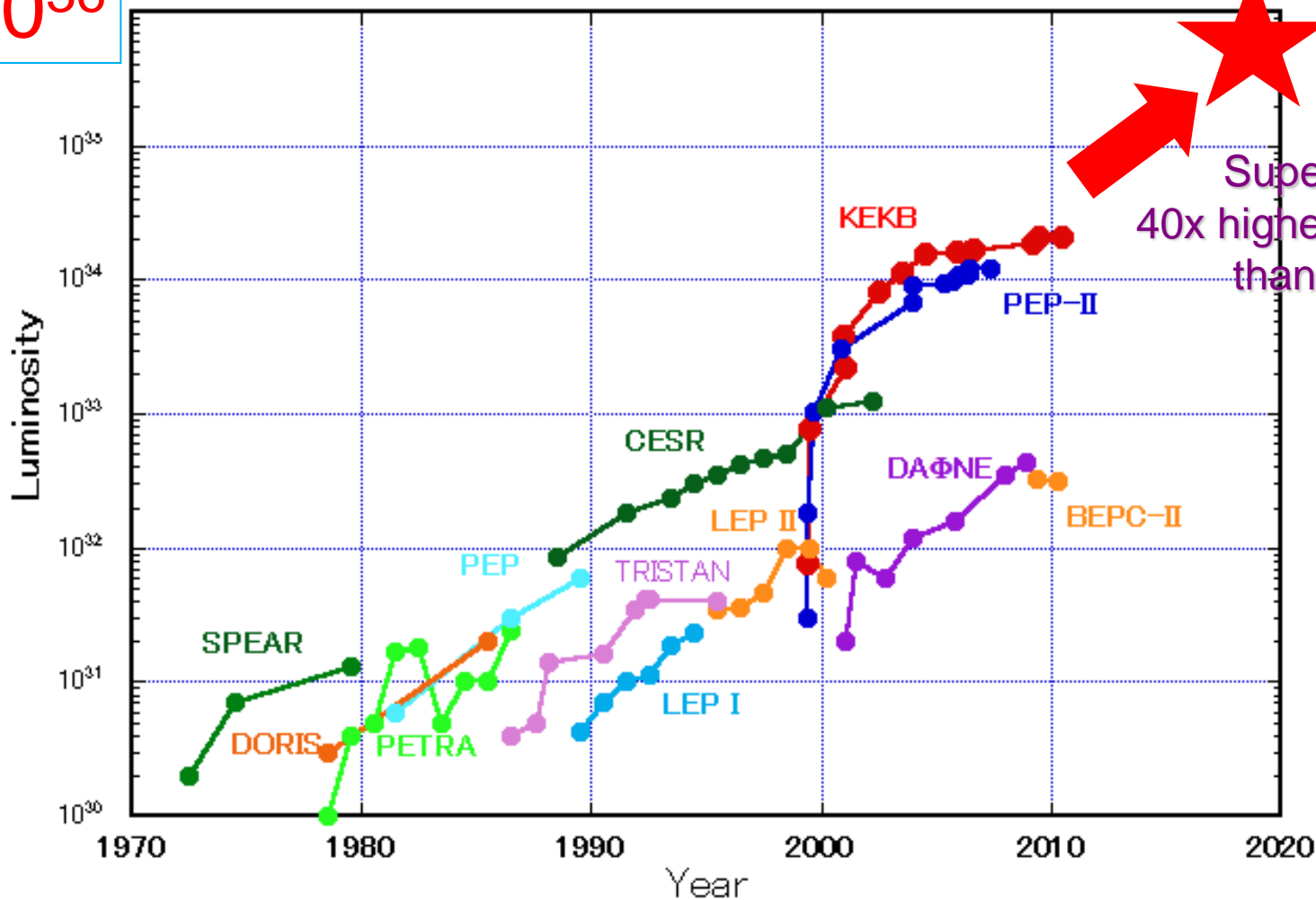
- Exactly two B mesons produced (at $\Upsilon(4S)$)
- High flavour tagging efficiency
- Detection of gammas, π^0 s, K_L s
- Very clean detector environment
 - ➔ can observe decays with several neutrinos in the final state)
- Well understood apparatus,
with known systematics, checked on control channels



SuperKEKB - Luminosity -

Peak Luminosity Trends (e^+e^- collider)

10^{36}



SuperKEKB
40x higher luminosity
than KEKB



SuperKEKB

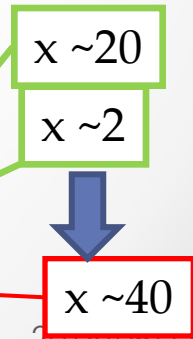
- Nano-Beam Scheme (1) -

- How to achieve $L \sim 10^{36}$: “Nano-Beam” scheme
 - double the beam currents
 - squeeze vertical beta function ($\beta_{y\pm}^*$) at IP (1/20)

$$L = \frac{\gamma_{\pm}}{2er_e} \left(\frac{I_{\pm} \xi_{y\pm}}{\beta_{y\pm}^*} \right) \left(\frac{R_L}{R_{\xi_y}} \right)$$

Lorentz factor $\rightarrow \gamma_{\pm}$
 Beam current $\rightarrow I_{\pm}$
 Beam-Beam parameter $\rightarrow \xi_{y\pm}$
 Geometrical reduction factors: 0.8-1.0 $\rightarrow \left(\frac{R_L}{R_{\xi_y}} \right)$
 Vertical beta function $\rightarrow \beta_{y\pm}^*$

	KEKB Achieved	SuperKEKB
Energy (GeV) (LER/HER)	3.5/8.0	4.0/7.0
ξ_y	0.129/0.090	0.090/0.088
β_y^* (mm)	5.9/5.9	0.27/0.41
I (A)	1.64/1.19	3.60/2.62
Luminosity ($10^{34} \text{cm}^{-2} \text{s}^{-1}$)	2.11	80

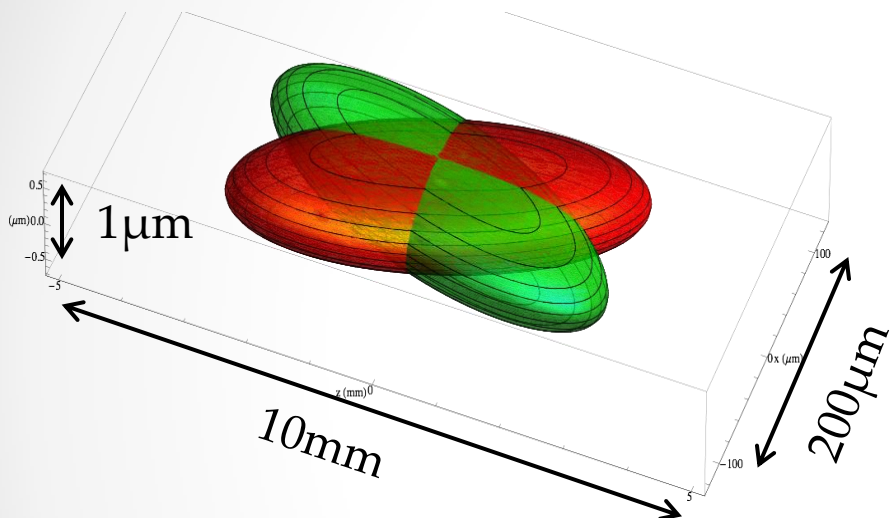


arXiv:1011.0352

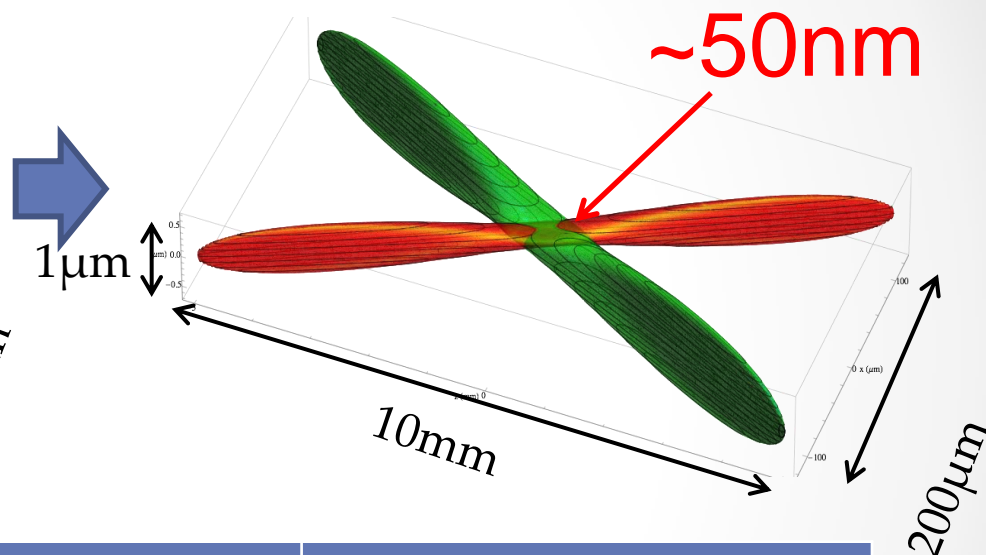
SuperKEKB

- Nano-Beam Scheme (2) -

KEKB (without crab)



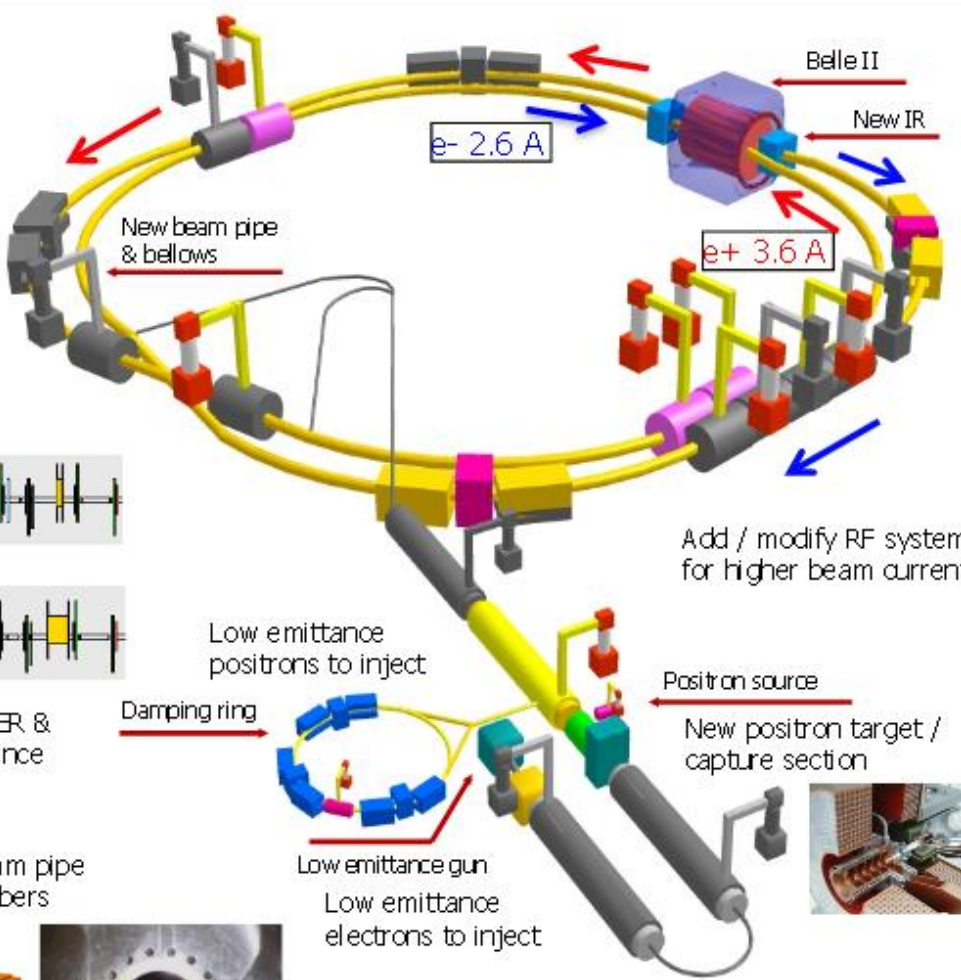
SuperKEKB



	KEKB	SuperKEKB
Beam Size @ IP	100 μm (H) \times 2 μm (V)	10 μm (H) \times 59nm (V)
Crossing angle	22mrad	83mrad

- Nano-Beam Scheme + a factor of 2 more beam current to increase luminosity
- Large crossing angle
- Change Beam energies to solve the problem of short life-time for the LER

SuperKEKB



Belle II
New IR

$e^- 2.6 \text{ A}$
 $e^+ 3.6 \text{ A}$

Colliding bunches

New superconducting / permanent final focusing quads near the IP

Replace short dipoles with longer ones (LER)

Redesign the lattices of HER & LER to squeeze the emittance

TIN-coated beam pipe with antechambers

Low emittance positrons to inject

Damping ring

Low emittance gun
Low emittance electrons to inject

Add / modify RF systems for higher beam current

Positron source
New positron target / capture section

New beam pipe & bellows

Beam
SR
[NEG Pump]
[SR Channel]
[Beam Channel]

To get 40x higher luminosity

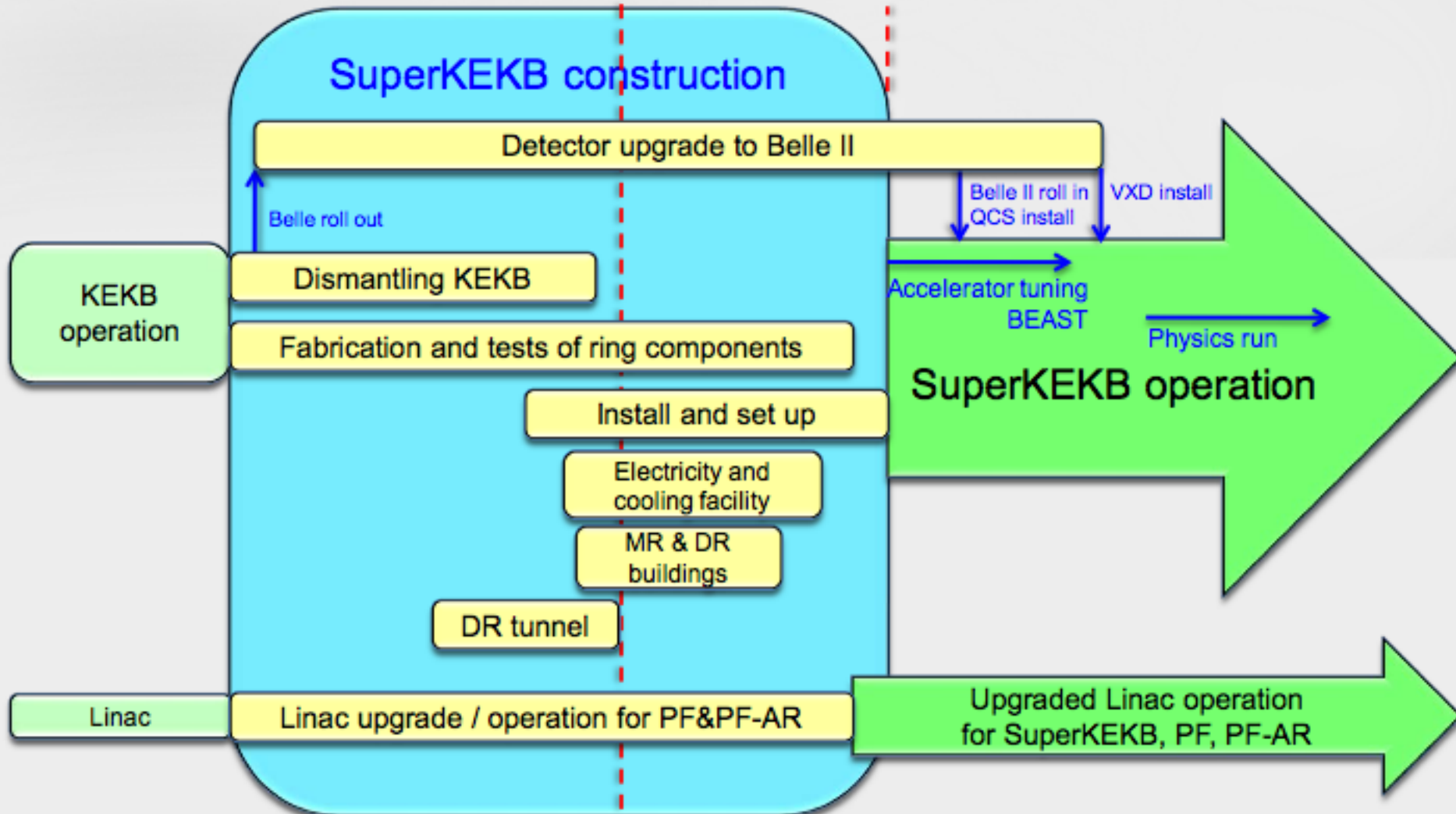
SuperKEKB/Belle II schedule

Calendar	2010	2011	2012	2013	2014	2015	2016	2017	...
Japan FY	2010	2011	2012	2013	2014	2015	2016	2017	...

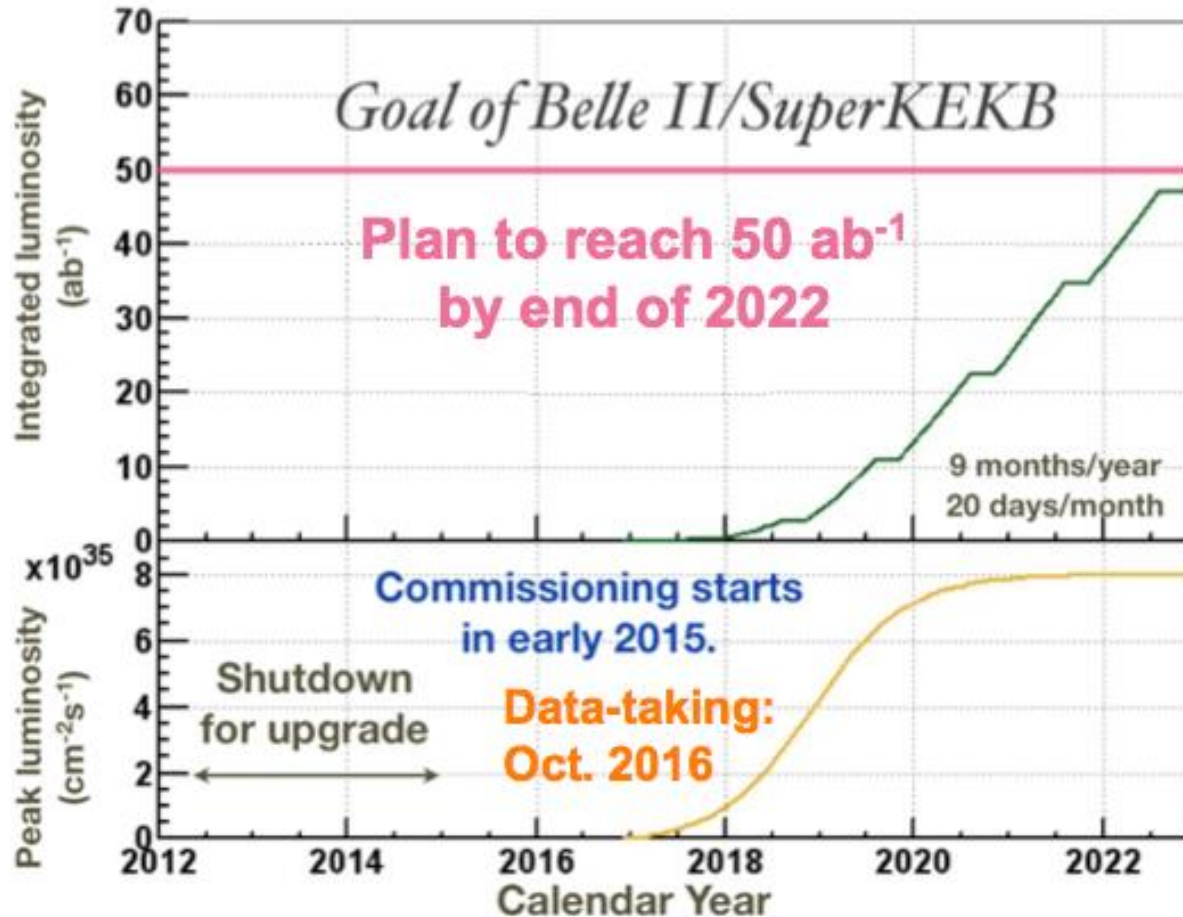
Mar. 2013

Jan. 2015

SuperKEKB construction

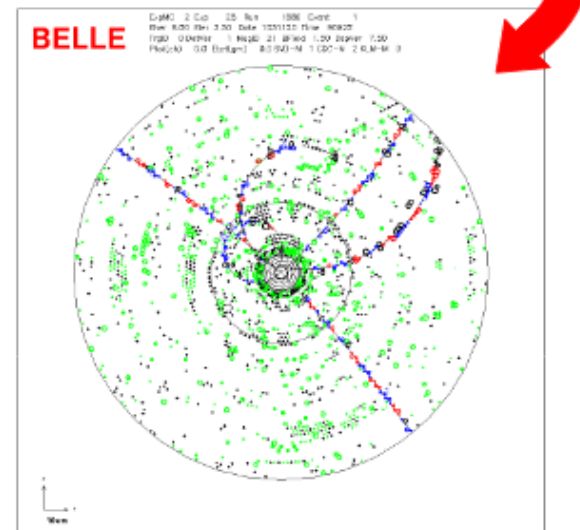
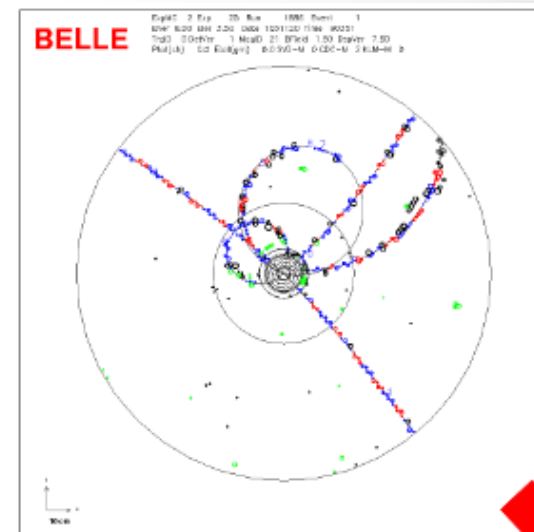


Timeline & goal

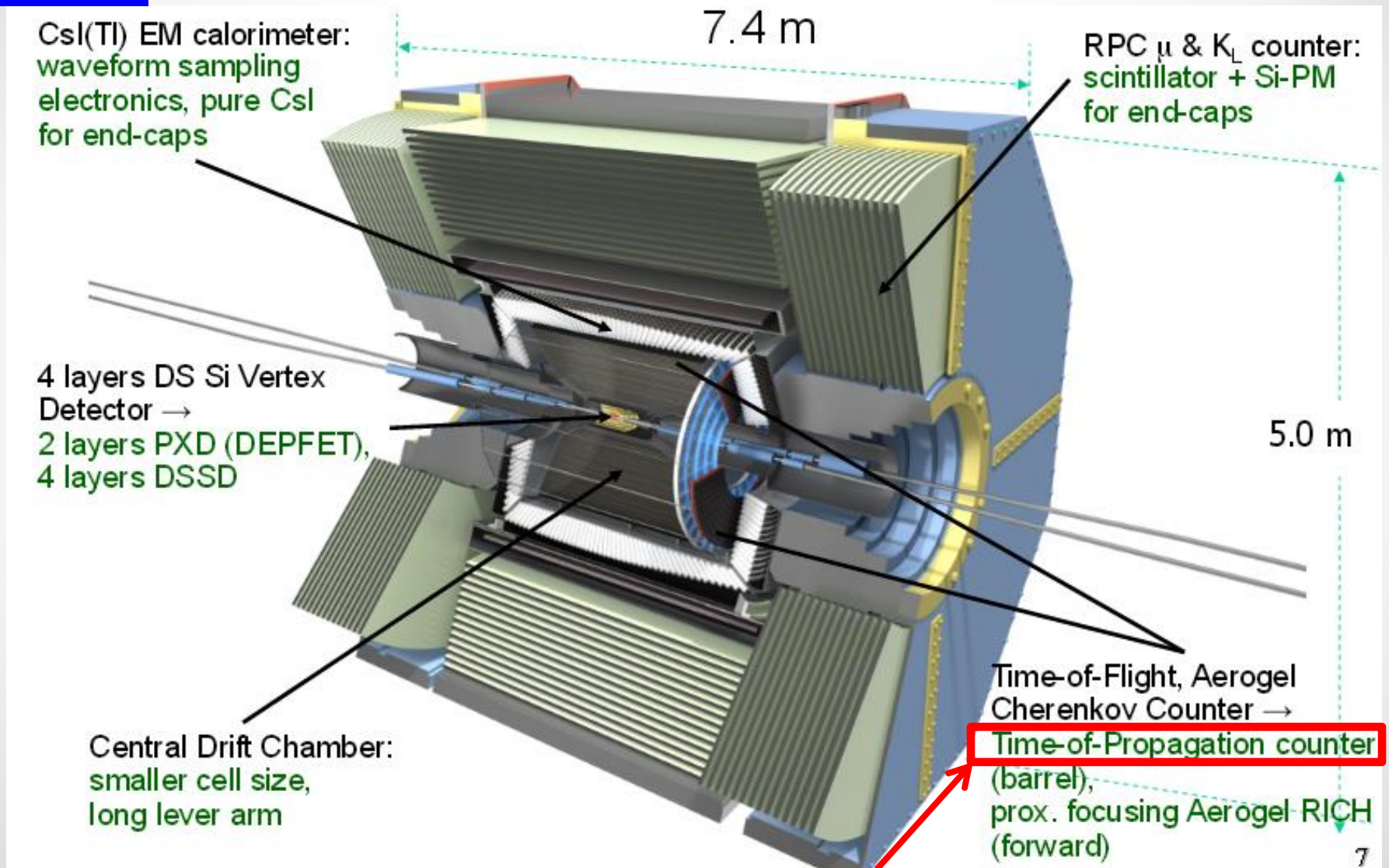


Detector upgrade

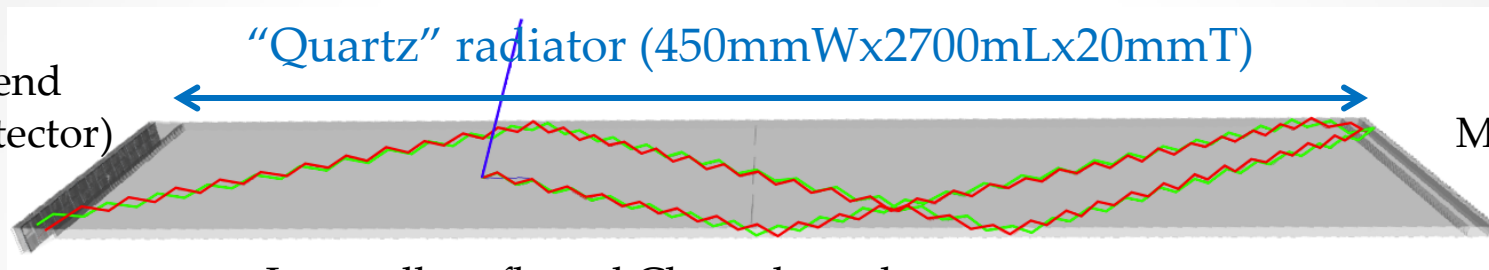
- Higher background (x20)
 - Radiation damage, occupancy
 - Fake hits and pile-up noise
- Higher event rate (x10)
 - Level1 trigger rate: 20kHz
 - High performace DAQ
- Important improvements
 - Hermiticity for full reconstruction analyses
 - IP and secondary vertex resolution
 - Ks and π^0 identification efficiency
 - Improve K/ π separation
- Detector components (arXiv:1011.0352)
 - SVD: 4DSSD lryrs → 2 DEPFET+4 DSSS lryrs
 - CDC: small cell, long lever arm
 - ACC+TOF: TOP + Aerogel RICH
 - ECL: waveform sampling
 - KLM: RPC → Scintillator + SiPM (endcaps)



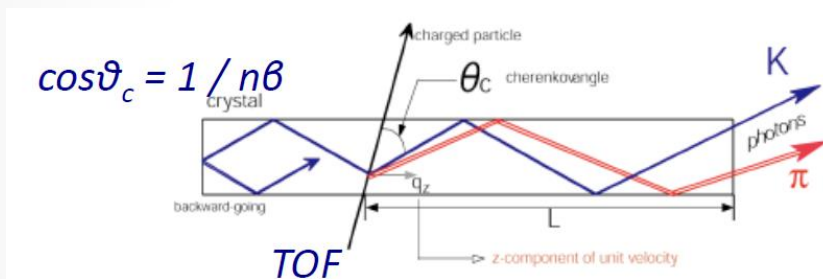
Belle II Detector



TOP counter



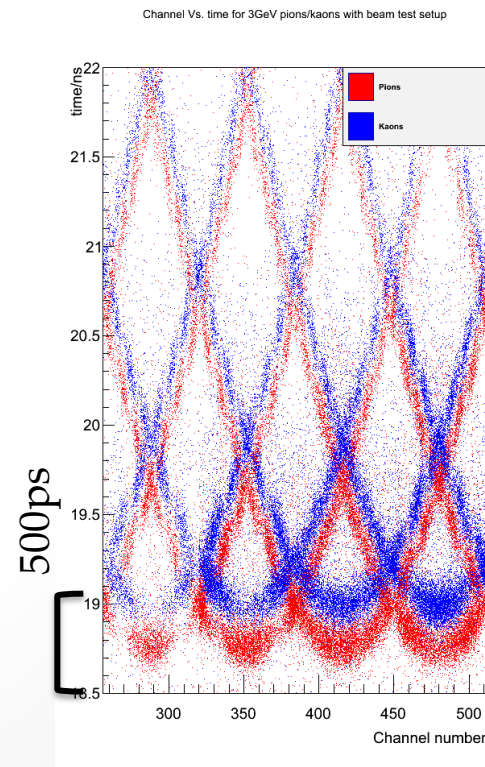
Internally reflected Cherenkov photons
Bounce off ≥ 100 times at the large faces.



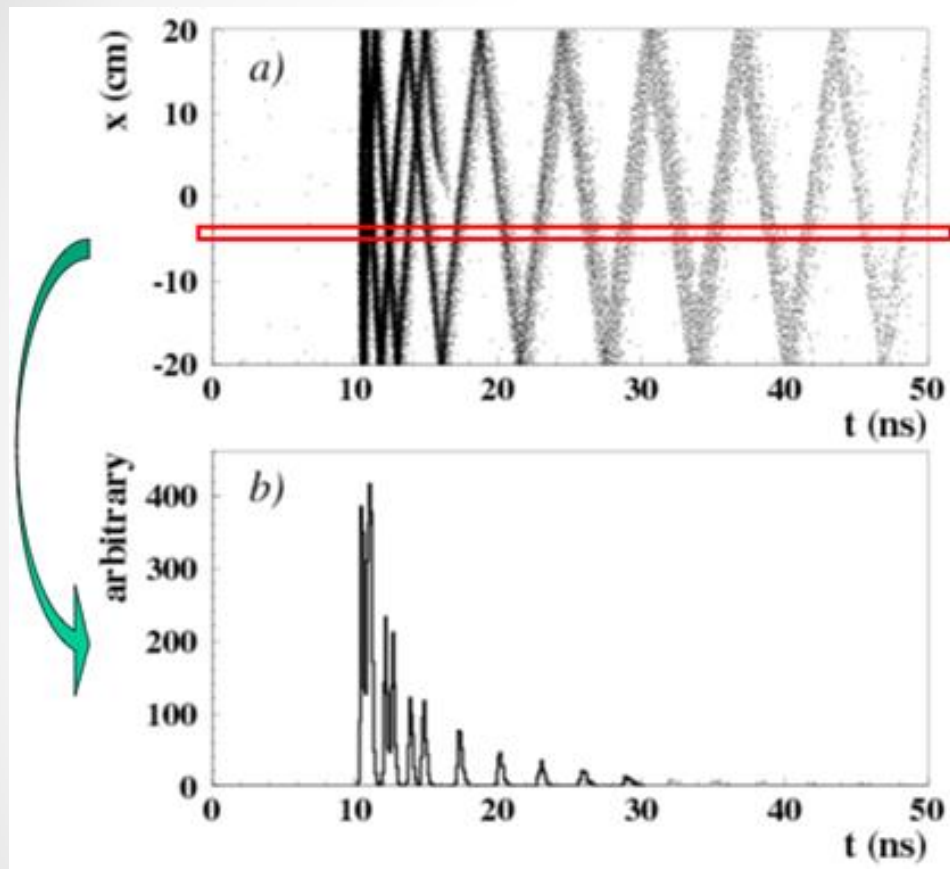
➤ Separation power (S)

$$S = \frac{\Delta TOF + \Delta TOP}{\sigma_{TOP}} \sqrt{N_{det}} \quad \sigma_{TOP} = \sqrt{\sigma_{PD}^2 + \sigma_{opt}^2}$$

- N_{det} : Number of photons detected (~ 20)
- σ_{PD} : time resolution (photo-detector + elec.) (~ 50 ps)
- σ_{opt} : chromatic dispersion ($> \sim 50$ ps)

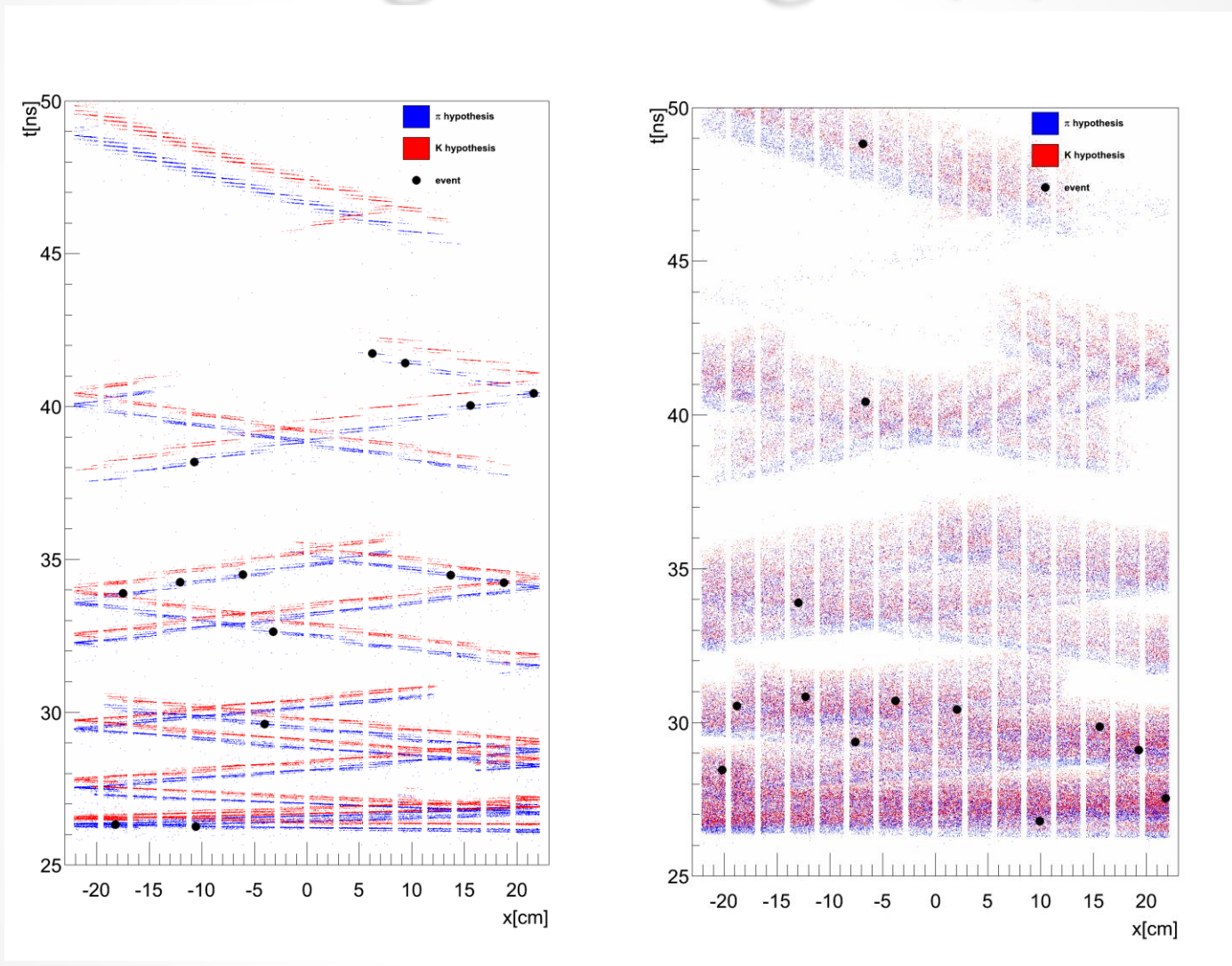


“Ring” image (1)

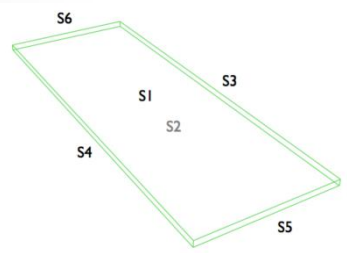
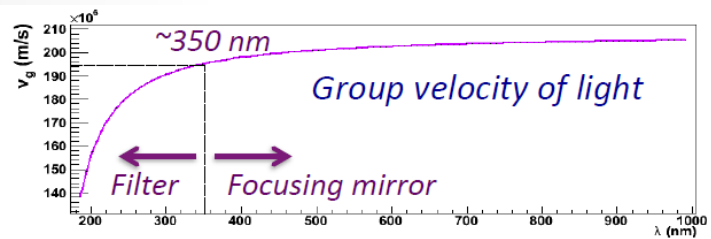
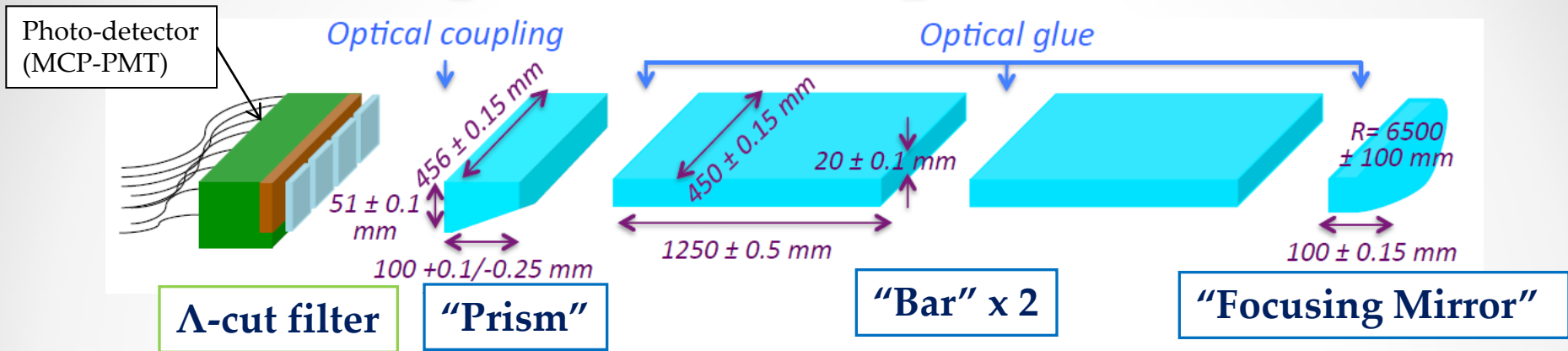


- Pattern in the coordinate-time space ('ring') of a pion hitting a quartz bar.
- Time distribution of signals recorded by one of the PMT channels:
 - ➔ Different for π and K (~shifted in time)

“Ring” image (2)



Optical components



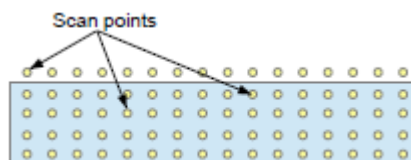
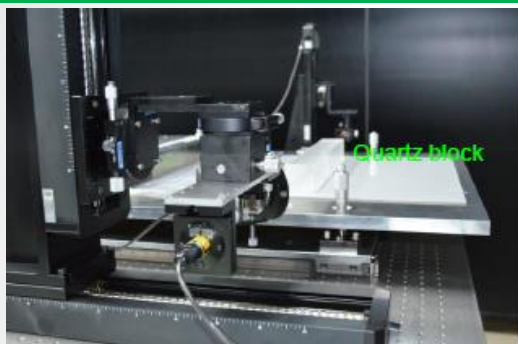
Tolerance	Specification	Comments
S1 \square (Datum A)	$\leq 6.3 \mu\text{m}$	Equal to 10 waves over full aperture of surface
S2 \square	$\leq 6.3 \mu\text{m}$	Equal to 10 waves over full aperture of surface
S3 \square (Datum B)	$\leq 6.3 \mu\text{m}$	Equal to 10 waves over full aperture of surface
S4 \square	$\leq 6.3 \mu\text{m}$	Equal to 10 waves over full aperture of surface
S5 \square (Datum C)	$\leq 25 \mu\text{m}$	Equal to 40 waves over full aperture of surface
S6 \square	$\leq 25 \mu\text{m}$	Equal to 40 waves over full aperture of surface
S1 // S2	≤ 4 arcsec	4 arcsec = 24 micron runout over 1.25 m
S1 \perp S3	≤ 20 arcsec	20 arcsec = 2 micron runout over 20 mm
S1 \perp S4	≤ 20 arcsec	20 arcsec = 2 micron runout over 20 mm
S1 \perp S5	≤ 1 arcmin	1 arcmin = 6 micron runout over 20 mm
S1 \perp S6	≤ 1 arcmin	1 arcmin = 6 micron runout over 20 mm
S3 // S4	$\leq 60 \mu\text{m}$	60 microns = 10 arcsec over 1.25 m as projected on datum A; note that an angular specification would over-constrain perpendicularity relative to S1
S3 \perp S5	≤ 20 arcsec	20 arcsec = 44 micron runout over 0.450 m; note that this tolerance is comparable to the flatness of the surface S5
S3 \perp S6	≤ 20 arcsec	20 arcsec = 44 micron runout over 0.450 m; note that this tolerance is comparable to the flatness of the surface S6
S5 // S6	≤ 20 arcsec	20 arcsec = 44 micron runout over 0.450 m

- Very tight requirements on material quality and dimensional tolerances.
- Quality Control & Precise Assembly (to be established)

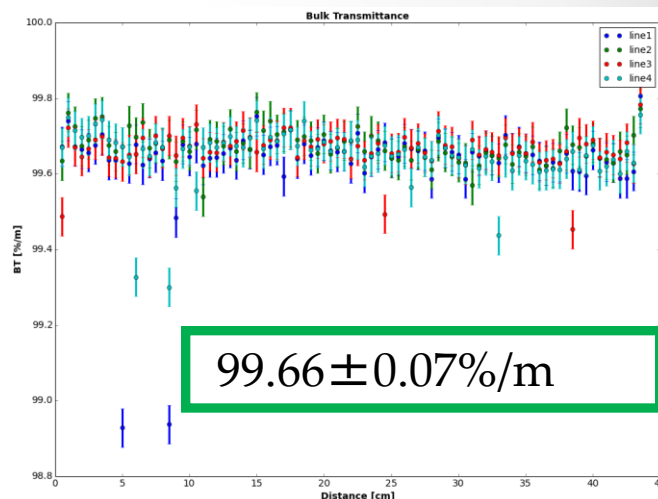
QA: quartz bar (1)

- Automatic scan system (Laser + PD)

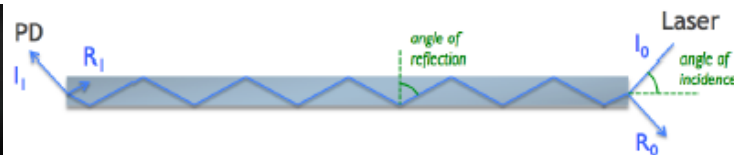
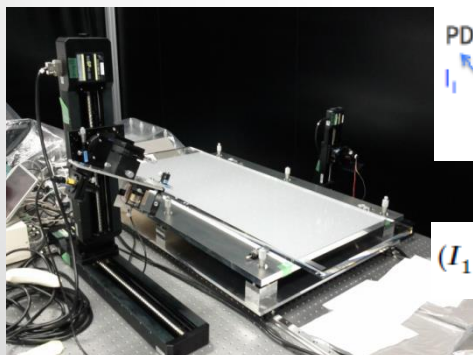
Bulk transmittance (spec. >98.5%/m)



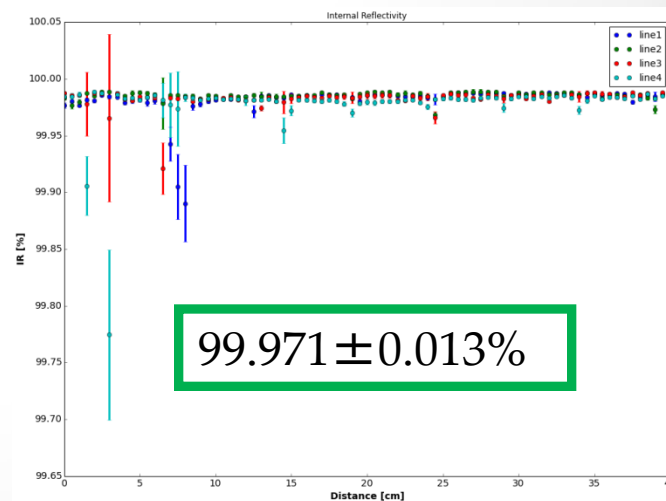
$$I_0(1 - R_0) \square (1 - R_1) = I_1$$



Internal reflectance (spec. >99.90%)



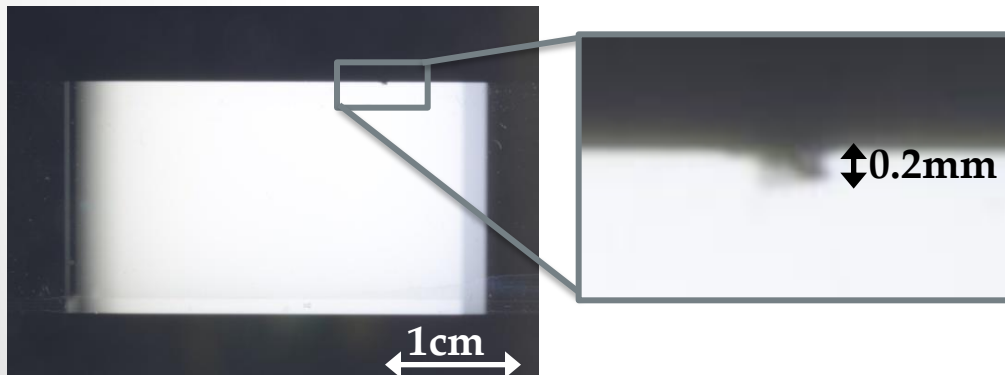
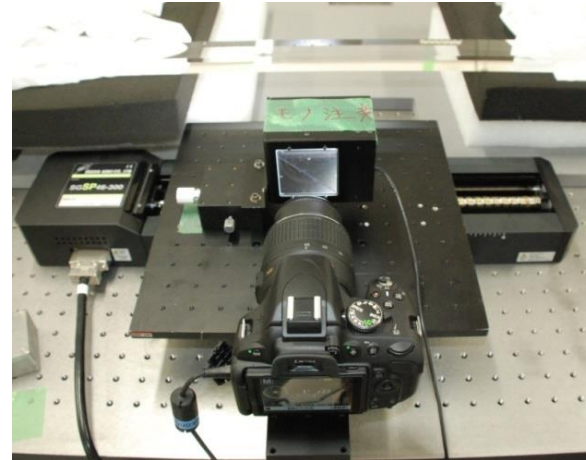
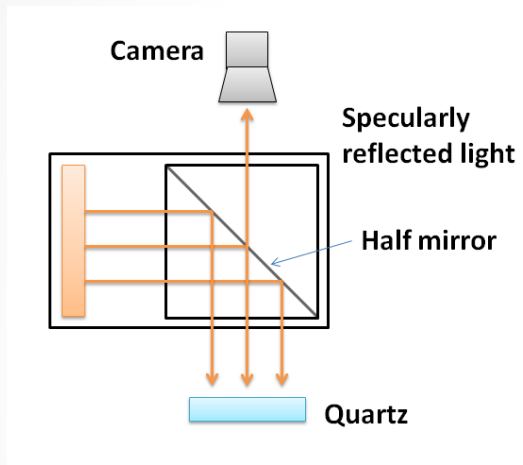
$$(I_1 - R_1) = (I_0 - R_0) \cdot \square \cdot \exp\left(-\frac{L}{\Lambda} \cdot \sqrt{1 + (Nh/L)^2}\right)$$



QA: quartz bar (2)

Chip/scratch inspection system

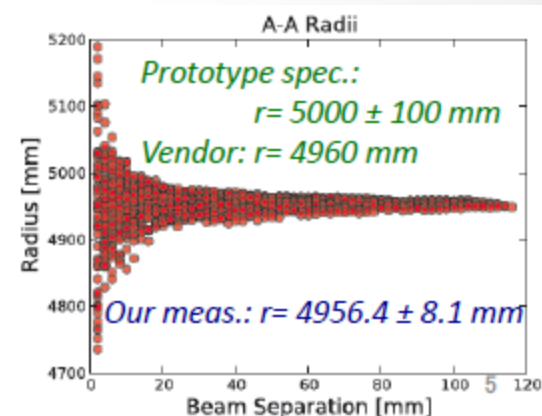
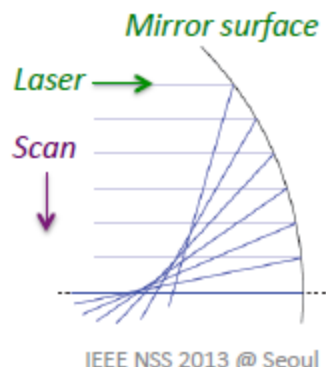
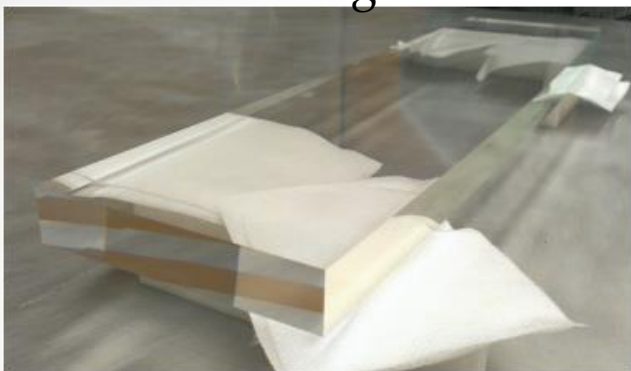
➤ To check for damage during transportation/handling



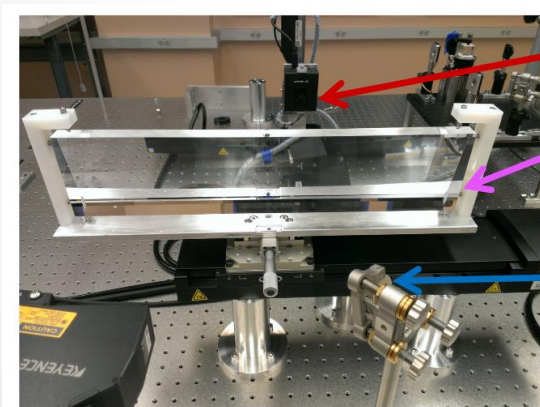
- Semi-automatic scan system
- Coaxial episcopic illumination
 - High-contrast chip images
 - Chip size analyzed with OpenCV-based softwares

QA: prism / mirror

➤ Mirror focal length



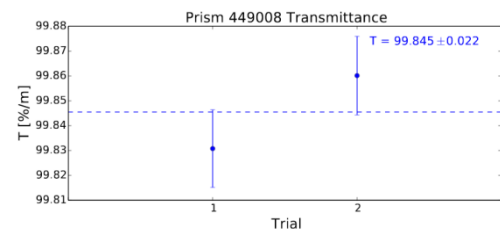
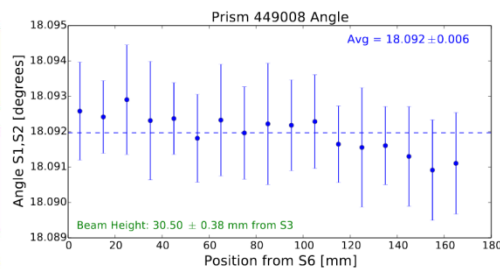
➤ Prism shape / bulk transmittance



CCD Beam Tracker on x-y-z- ϕ stage

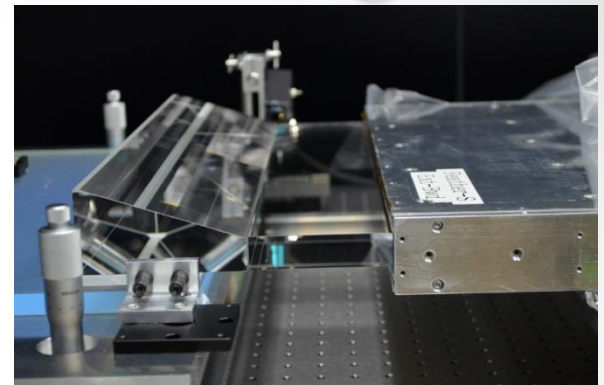
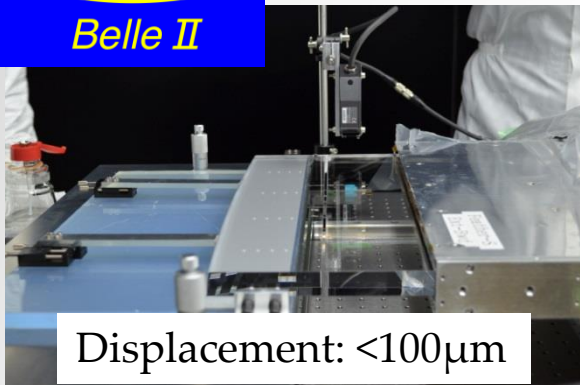
Prism on 250mm travel x-stage and 25mm z-stage

Beam steering mirror

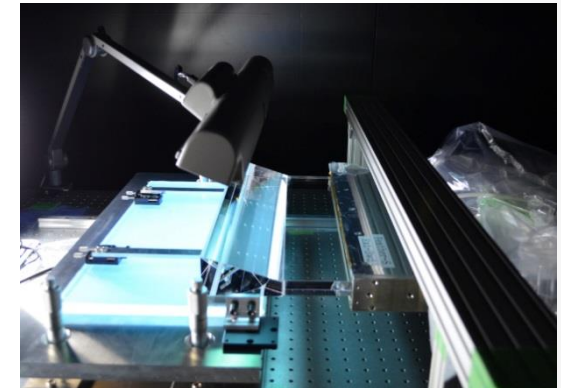
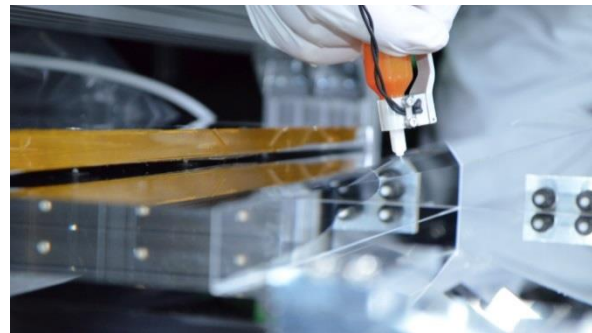


➤ Acceptance test system @ UC: working well

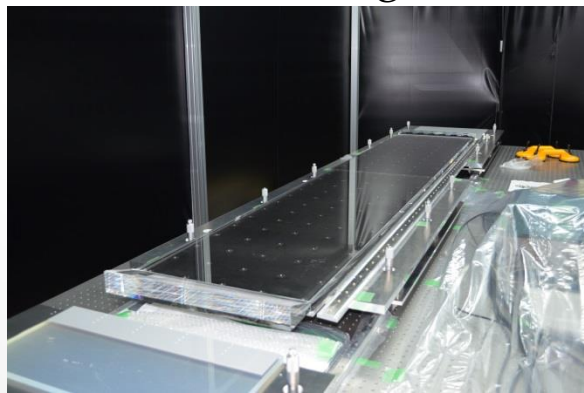
Quartz assembly (Gluing)



(1) Alignment (using the laser displacement sensor, autocollimator)



(2) Put glue on the surfaces & UV Light Curing



Gluing succeeded
under clean-room conditions
(class 100-1000)

Quartz procurement

- 16 + 2(spare) sets of the components to be produced
 - The first set has been delivered & tested
 - No problem on packing and transportation
 - 2 bars, 4 prims and 1 mirror pass acceptance tests.

➔ All quartz optics for the first TOP module: Ready for assembly

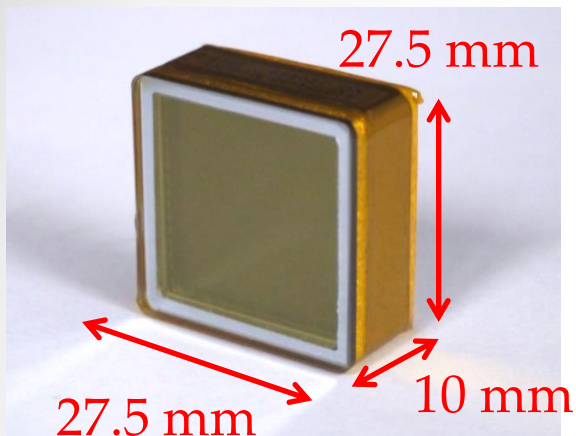
	Bar 1	Bar 2	Prism	Mirror
Delivered	2	1	4	4
Tested	1	1	4	2

- 4 bars will be delivered & tested in June.

➔ 4 sets of quartz optics will be ready for assembly this summer.

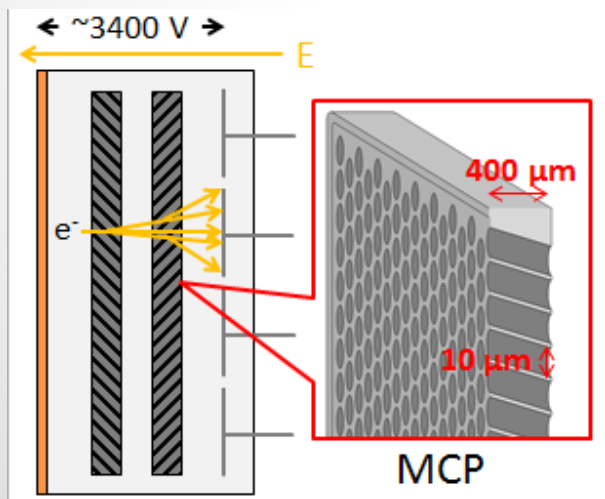
- The delivery schedule has been significantly delayed.
 - Delayed 3-8 months.
 - Grinding process didn't go well...
- Module assembly procedure has been revised to catch up the original schedule.
 - Multi vendor production
 - Two TOP assembly lines

Photodetectors (MCP-PMT)



➤ MCP-PMT

- Square-shape to minimize the dead space
- High-gain for single photon detection
➔ 2×10^6 at nominal HV
- Fast time response
➔ Transit Time Spread (TTS) < 50 ps
- High quantum efficiency (QE)
➔ $QE > 24\%$ (a.v. 28%) @ $\lambda = 380$ nm
- Low dark noise rate
➔ < 100 kHz
- Operative in 1.5 T



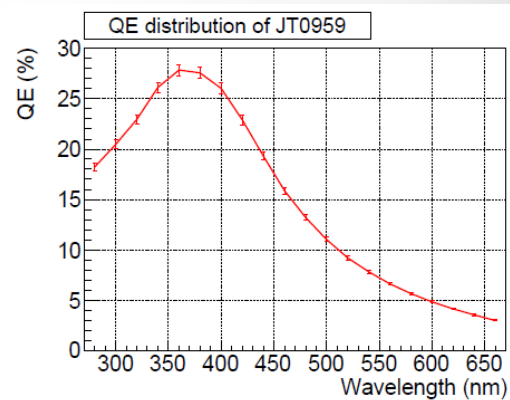
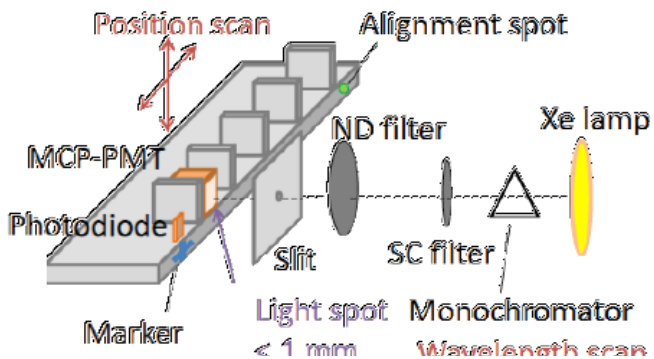
SL-10 specification

Photo-cathode	NaKSbCs
Anode	4 x 4
Collection efficiency	50-55%
Nominal HV	~ 3.4 kV

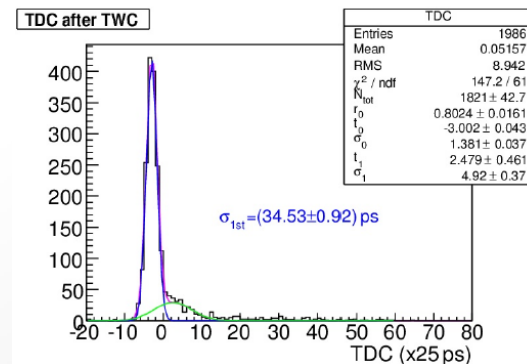
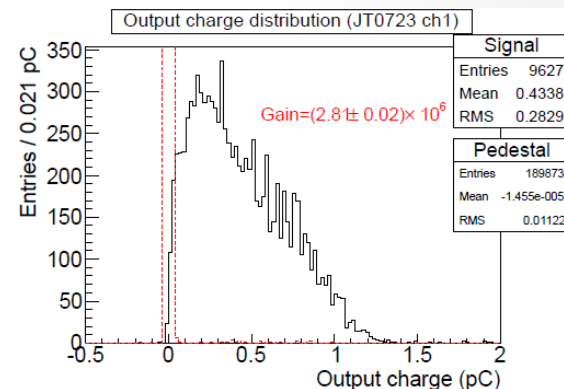
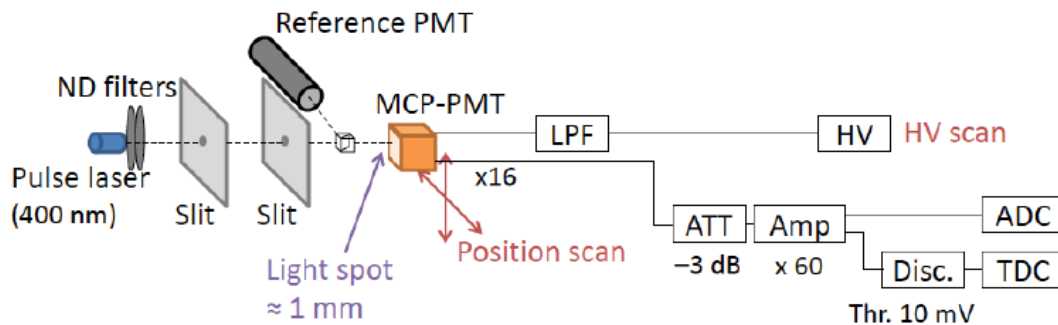
MCP-PMT measurement (1)

- Quantum efficiency (QE)
 - Photocathode current measurement

$$QE_{MCP} = I_{MCP} / I_{PD} \times QE_{PD}$$



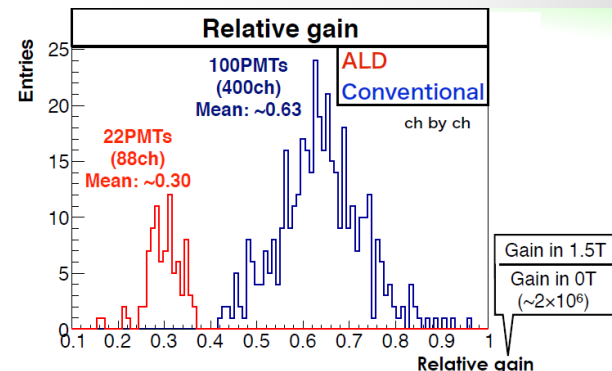
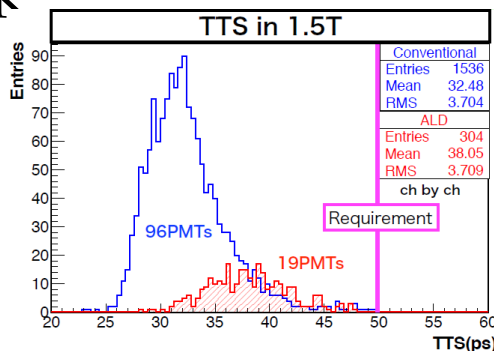
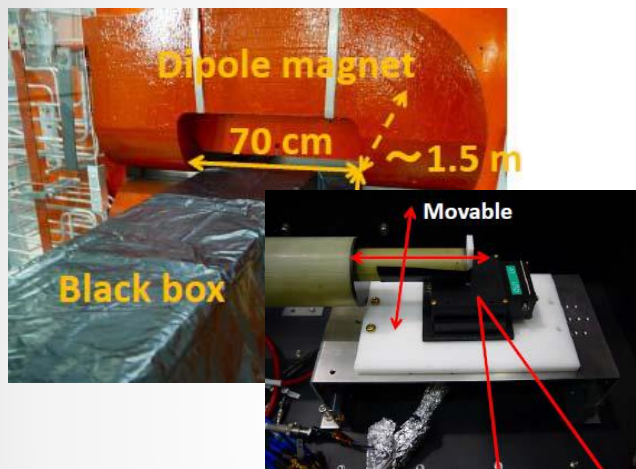
- Gain and Time Transit Spread (TTS)
 - Single photon measurement



MCP-PMT measurement(2)

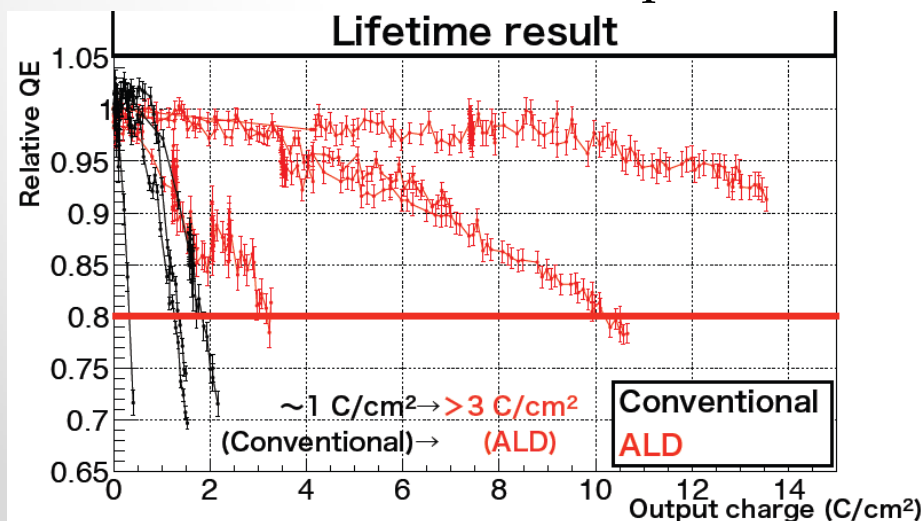
T. Yonekura, TIP2014

➤ Test in magnetic field @ KEK



- TTS in 1.5T: ~40ps
- Gain in 1.5T: enough to detect single photon
- Measurement underway

➤ Photocathode lifetime improvement



- Lifetime depends on output charge
- Conventional PMT: $\sim 0.5\text{-}2\text{C}/\text{cm}^2$
- ALD-PMT: $> 3\text{C}/\text{cm}^2$

(c.f.) $2\text{-}4\text{C}/\text{cm}^2/50\text{ab}^{-1}$ at 5×10^5 gain
 ➔ The lifetime to be improved further



MCP-PMT mass production

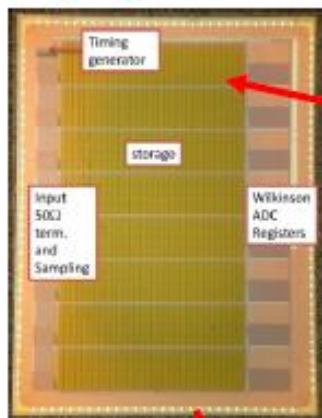
- 32PMTs/ module → 512PMTs / 16 TOP modules
- About 50% of the PMTs will be ALD-MCP-PMTs
- Conventional MCP-PMTs will be used in half-gain operation
 - The lifetime is expected be $\sim 2 \text{ C/cm}^2$.
 - Still need PMT replacement procedure.
- PMT measurements / inspections are in progress.
 - QE measurement: 474
 - Gain, TTS measurement: 324 (ALD: 80)
 - Gain measurement in 1.5T: 122 (ALD: 22)
 - TTS measurement in 1.5T: 117 (ALD: 19)

Front-end Electronics (1)

TOP Readout

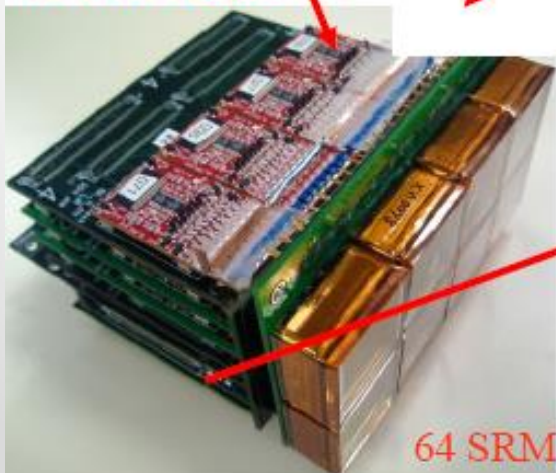
$\leq 50\text{ps}$ single photon timing

BLAB Waveform sampling ASIC



8k channels

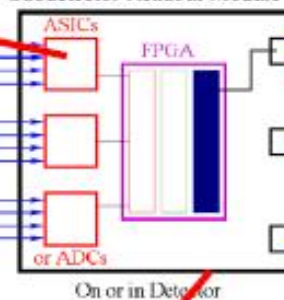
1k 8-ch. ASICs



64 SRM

64 SRM

Subdetector Readout Module



On or in Detector

- FPGA firmware consists of 3 parts:
- 1) ASIC/ADC driver (common)
 - 2) Trigger feature extract (subdet. specific)
 - 3) Unified DAQ transport protocol

Digital control (SCROD)



8 COPPER

COPPER

FINESSE

32 DSP FINESSE

Global Decision Logic

9 TRGmod

Clock/Event Timing Distribution

FTSW clock, trigger, programming

8 FTSW



Front-end Electronics (2)

- High-speed waveform sampling ASICs (“IRS”)
 - Developed by Univ. of Hawaii.
 - Targeting the timing jitter $\sigma < 50\text{ps}$
 - Hardware/firmware/Mechanics development
 - ➔ $\sigma \sim 60\text{ps}$ with the intermediate board stack
 - ➔ Various calibrations and updates are necessary.

LEPs Beam Test Electronics:

- IRS3C/Spartan 6 FPGA



Intermediate:

- POGO pins
- IRS3C/Spartan 6 FPGA



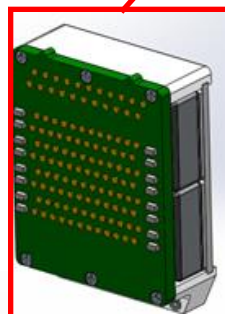
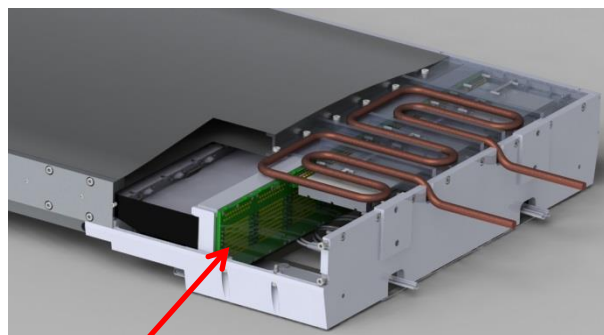
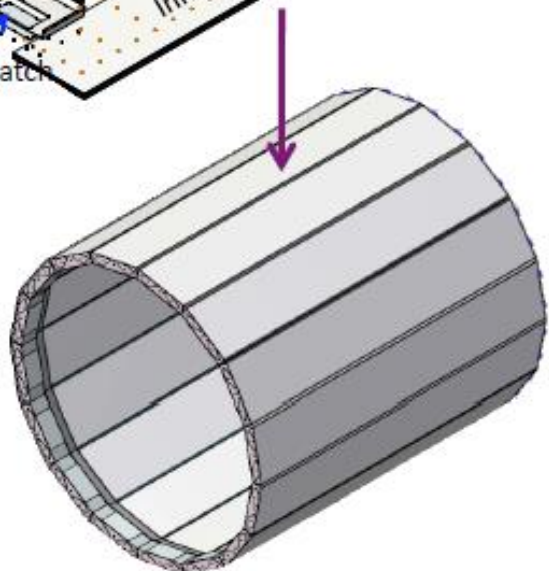
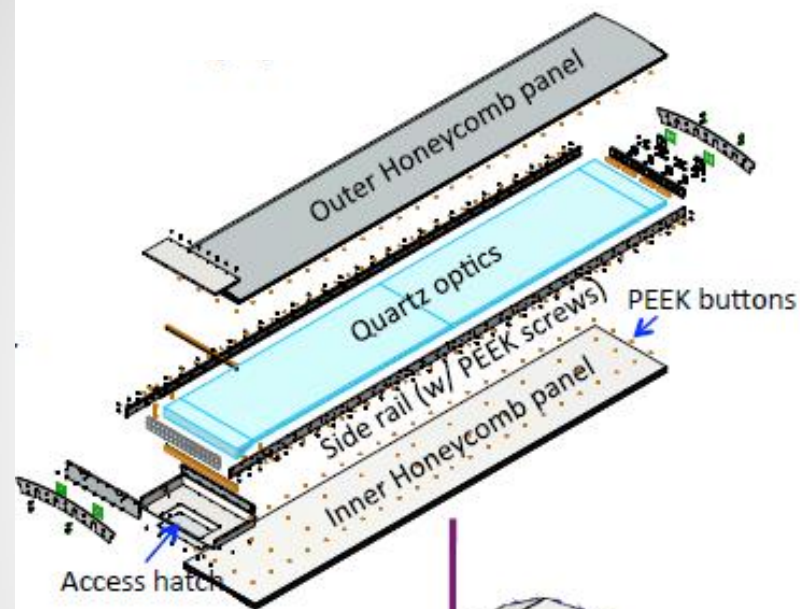
Final Electronics

- POGO pins
- IRSX/Zynq SOC

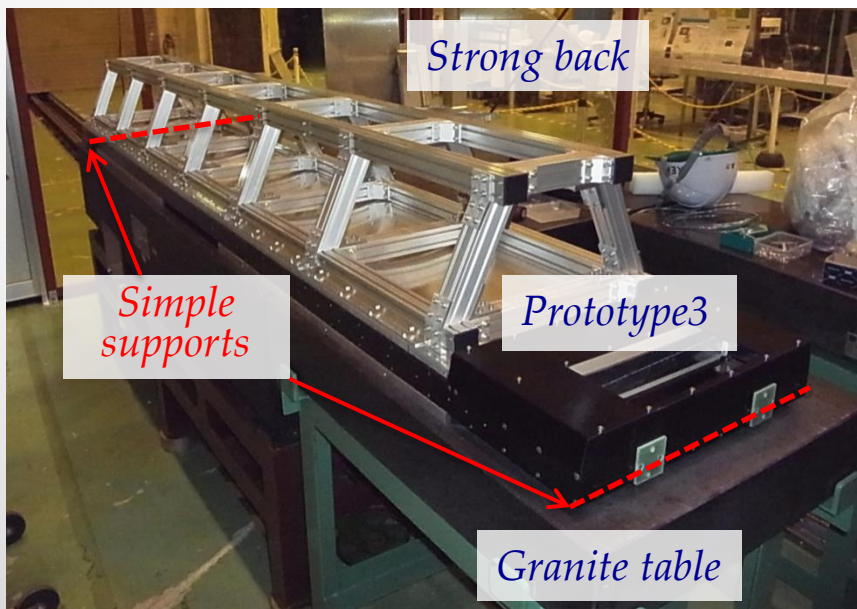
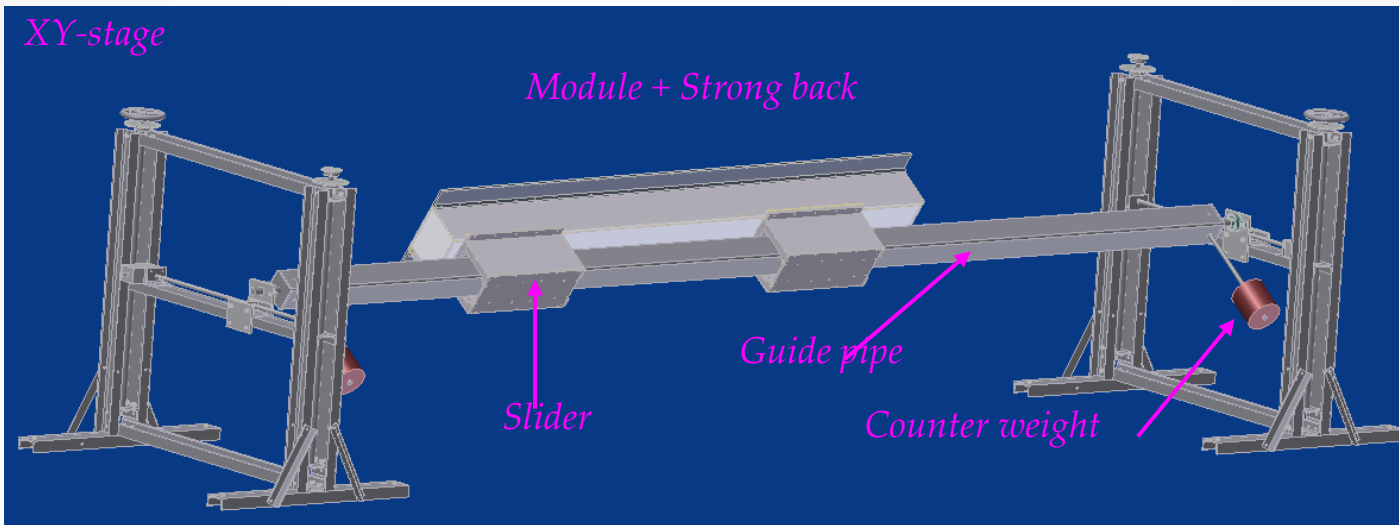


Mechanics – QBB-

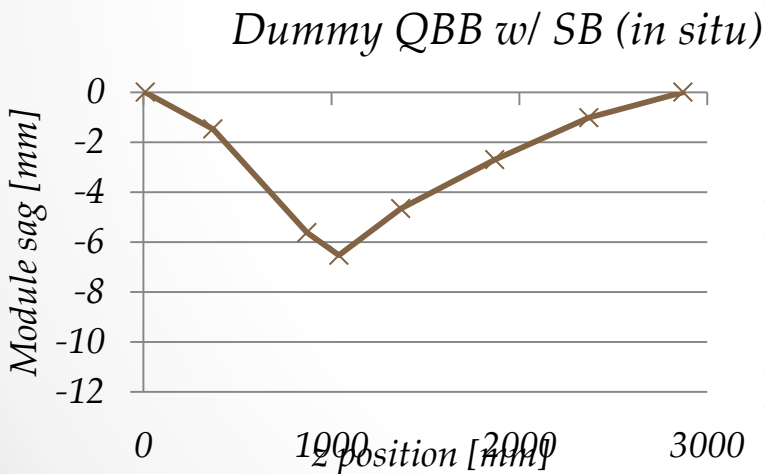
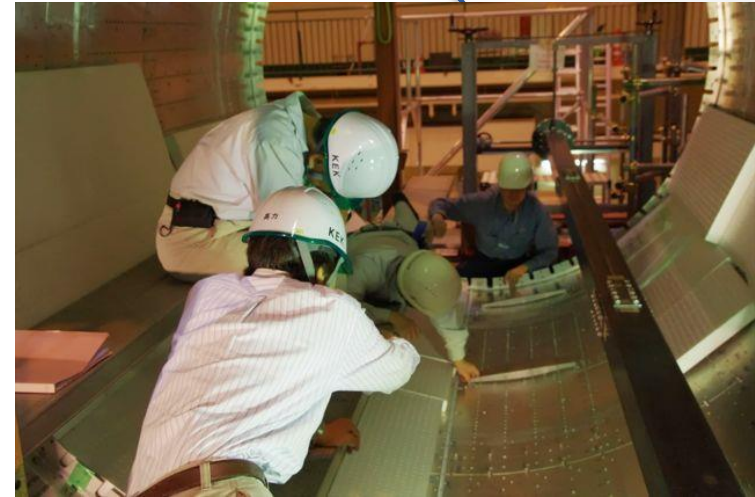
- Quartz Bar Box (QBB)
- Module container
 - Aluminum Honeycomb panels
 - PEEK material to support the quartz optics
- Final prototyping / producing: on-going
 - Prism/front-end closure
 - Optical coupling
 - Gas sealing



TOP installation jig



TOP installation test (in-situ)



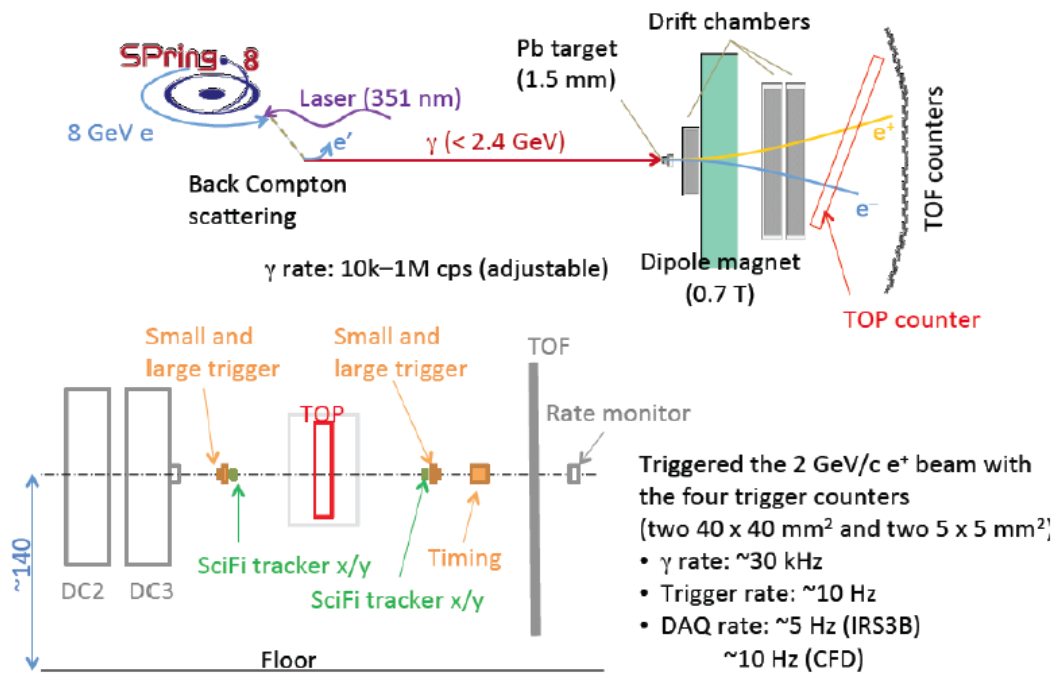
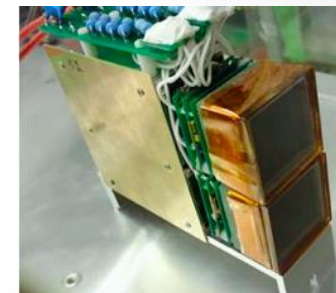
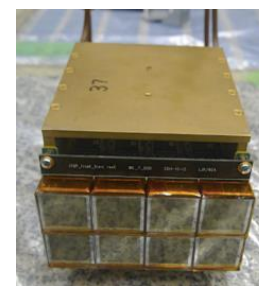
- Guide pipe deflection coupled to strong back and QBB because of rigid coupling of sliders on guide pipe during this test
 - Design modified to provide clearance so angle of sliders is not transferred to QBB
- ↓
- New SB → Maximum deflection (simple support at ends) <0.8 mm
 - Sliders also modified to minimize the sag.

Beam Test @ SPring-8/LEPS (1)

- Performance studies using 2 GeV/c e^+
- Full-scale prototype
 - almost the final optics
 - 32PMTs for full photo-coverage
 - Two types of front-end electronics
 - IRS3 (baseline)
 - (conventional) “CFD” modules

7

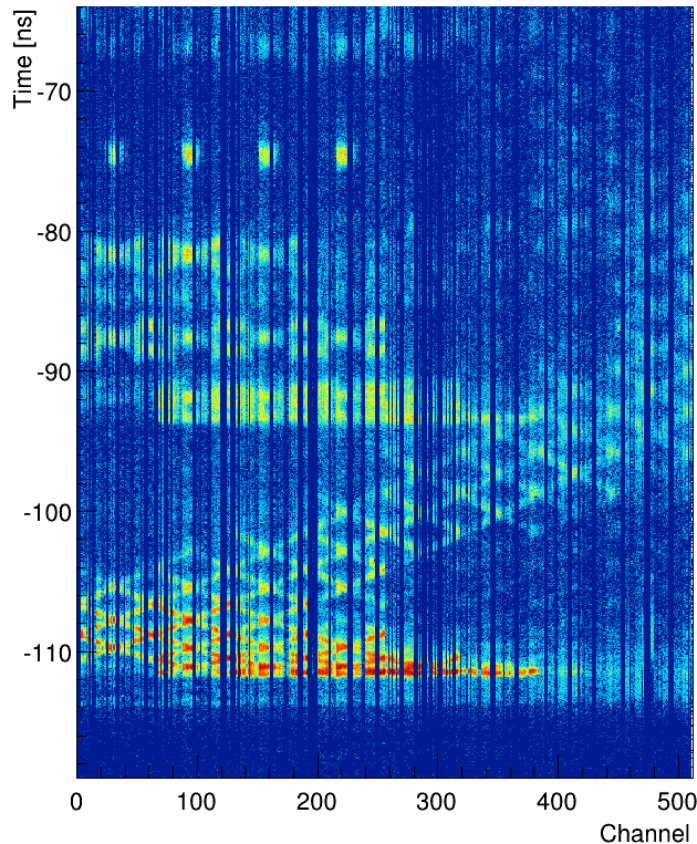
Setup for IRS3B Experiment 3 ($\cos\theta = 0.43$)



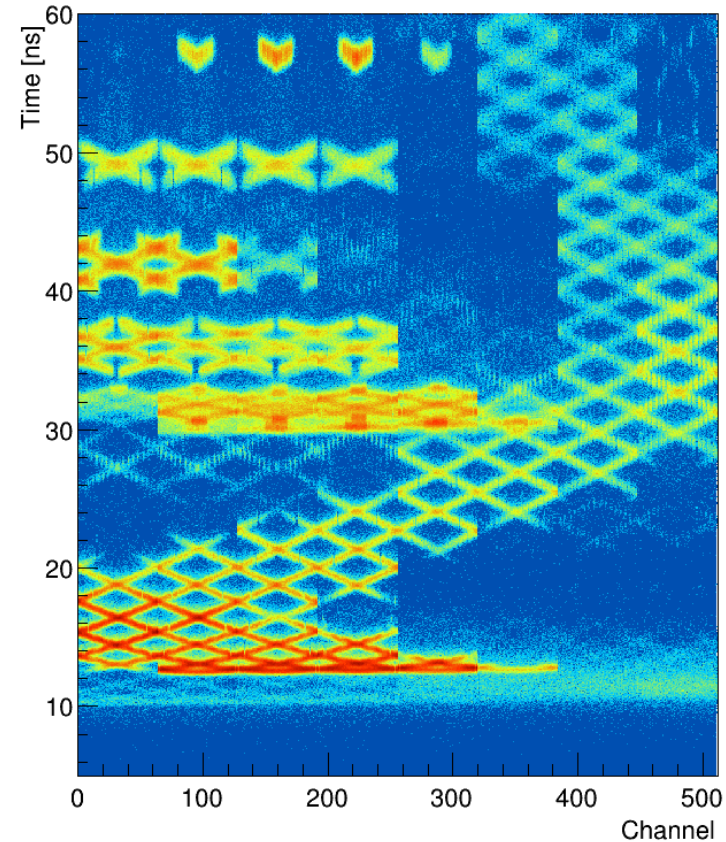
- “IRS3B”: Based on a waveform-sampling ASIC 4×10^9 samples /sec.
- “CFD”: Based on constant fraction discriminator MCP-PMT 16 channels are merged into 4 at the MCP-PMT socket ($\sigma \sim 50$ psec.)

Beam Test @ SPring-8/LEPS (2)

Data (IRS3)



MC (IRS3)

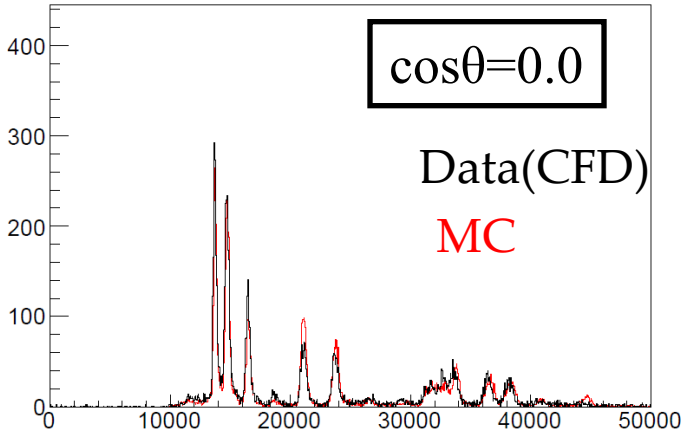


➤ Cherenkov Ring Image (preliminary)

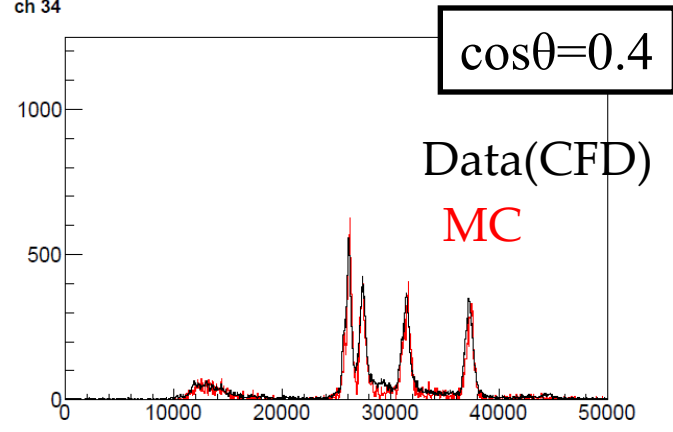
- Beam conditions: $\cos\theta = 0$, $x = 0$
- Time resolution: 156ps (Time jitter (IRS3B) ~ 100 ps)

Beam Test @ SPring-8/LEPS (3)

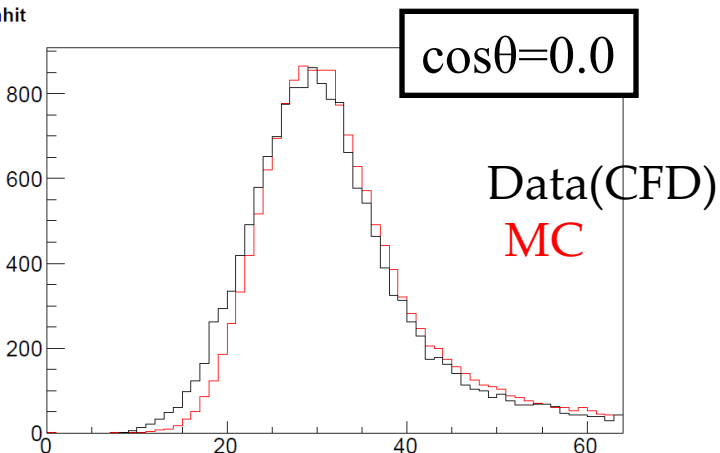
ch 64



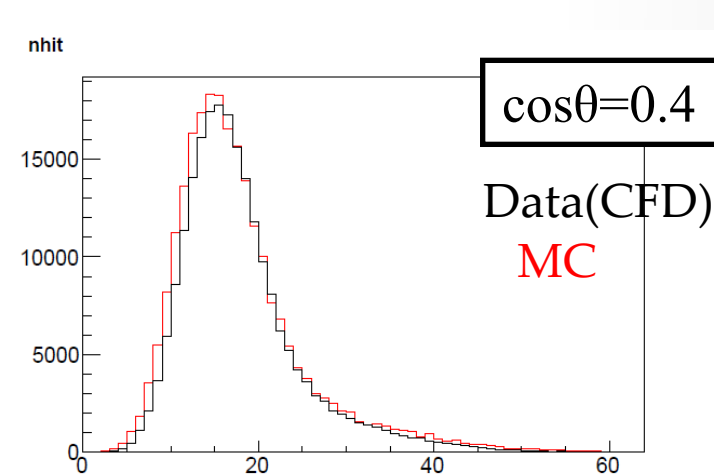
ch 34



nhit



nhit



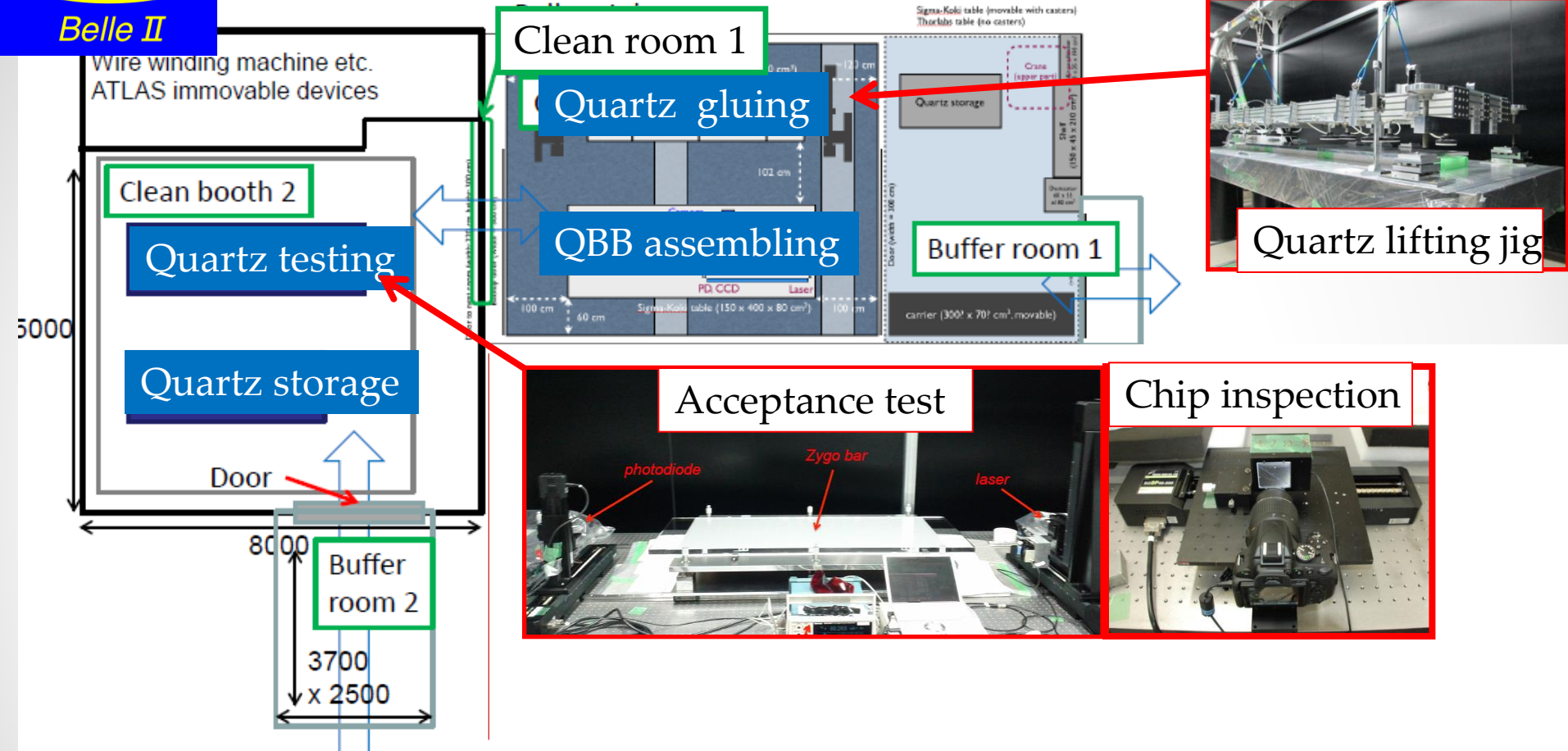
- Data taken with CFD modules
- Time resolution: 110-120ps
- Good agreement between data and MC

Physics Performance

Decay mode	π efficiency with 2% K fakes π rate 100ps electronics jitter	π efficiency with 4% K fakes π rate 100ps electronics jitter	π efficiency with 4% K fakes π rate 50ps electronics jitter
$B \rightarrow \pi \eta \gamma$ vs $K \eta \gamma$	84.28 +/- 0.91	94.13 +/- 0.57	93.22 +/- 0.52
$B^+ \rightarrow \rho \gamma$ vs $K^* \gamma$	80.71 +/- 1.07	93.19 +/- 0.67	92.55 +/- 0.62
$B^0 \rightarrow \rho \gamma$ vs $K^* \gamma$	81.50 +/- 0.78	92.63 +/- 0.49	92.13 +/- 0.46
$B^+ \rightarrow \pi \pi \pi^0 \gamma$ vs $K \pi \pi^0 \gamma$	83.55 +/- 0.76	94.03 +/- 0.46	93.47 +/- 0.43
$B^0 \rightarrow \pi \pi \pi \gamma$ vs $K \pi \pi \gamma$	79.50 +/- 0.67	91.48 +/- 0.45	92.56 +/- 0.38
$B^+ \rightarrow \pi \pi \pi \pi^0 \gamma$ vs $K \pi \pi \pi^0 \gamma$	75.00 +/- 0.72	90.50 +/- 0.44	91.01 +/- 0.38
$B^0 \rightarrow \pi \pi \pi \pi \gamma$ vs $K \pi \pi \pi \gamma$	76.33 +/- 0.37	90.00 +/- 0.33	92.20 +/- 0.31

- TOP Beam Test performance implemented in BASF2 for Belle II Physics Studies
- ➔ Negligible improvement from electronic resolution 100ps ➔ 50ps
(Beam test performance adequate to do 1-2% measurement of $|V_{td}|/|V_{ts}|$)

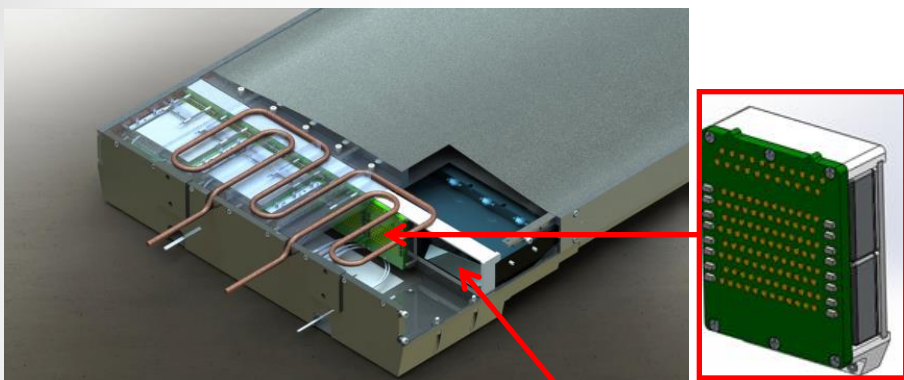
Quartz/QBB assembly



- Belle II TOP fabrication line constructed @ KEK-Fuji
 - Class 100-1,000 large cleanrooms
 - Quartz testing / handling / assembly procedures: well established
 - Quartz Bar Box assembly under preparation

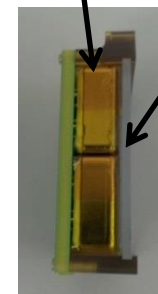
PMT module assembly

➤ PMT module

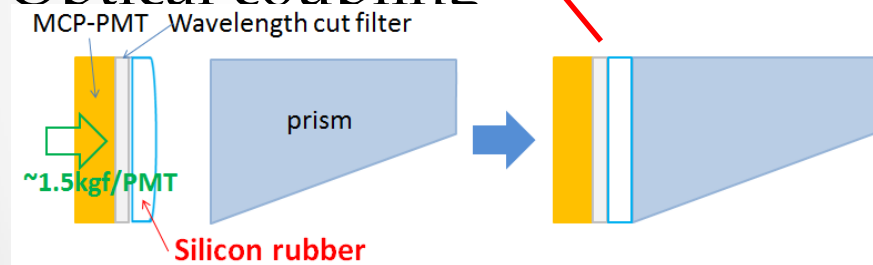


4 MCP-PMTs

λ -cut filter



➤ Optical coupling



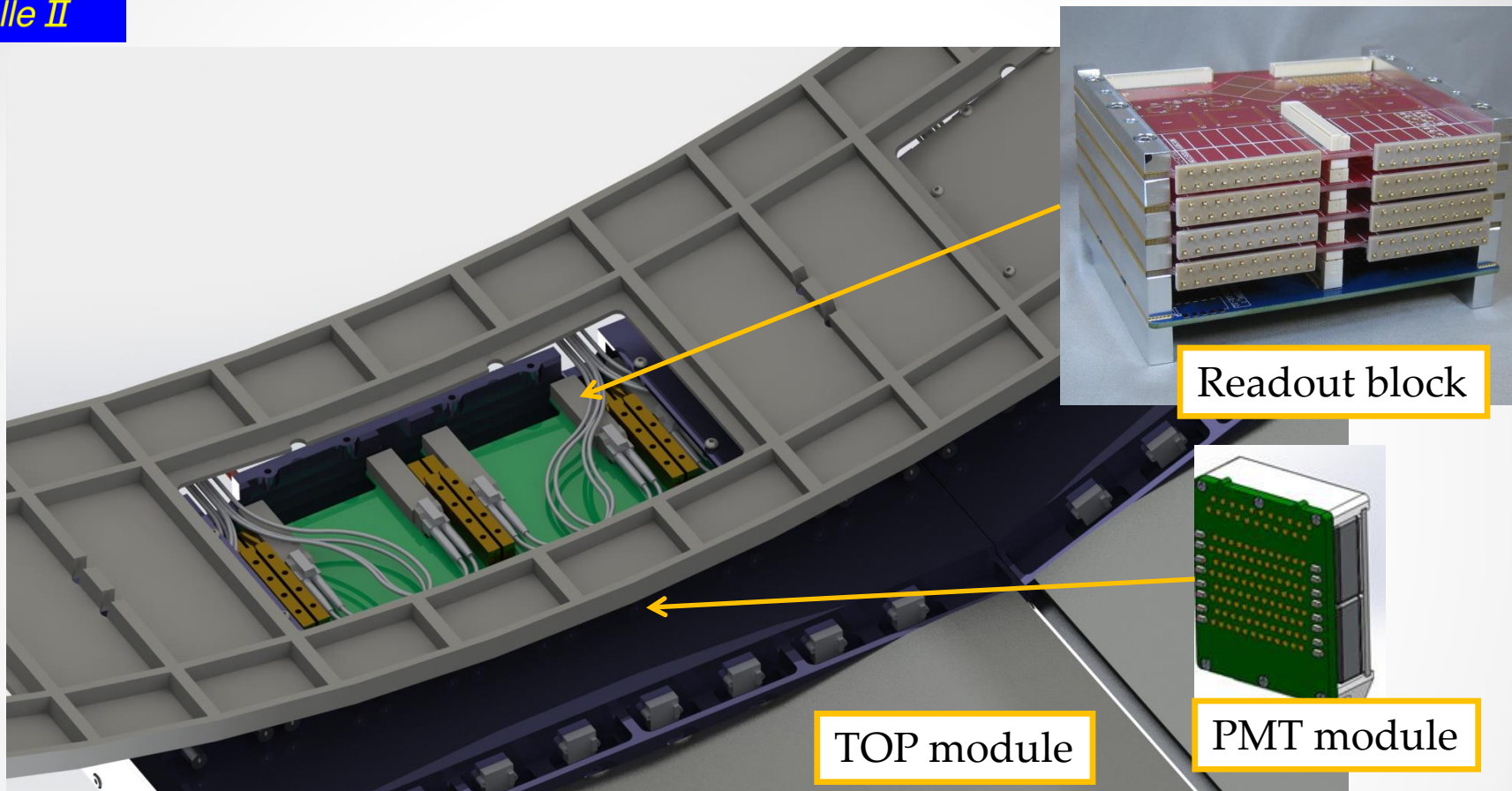
Clean bench for optical cookie & PMT module @ KEK

➤ TSE3032 silicon rubber: optical cookie

- Easy to remove MCP-PMTs from quartz prism

➤ Procedures for optical coupling are being finalized.

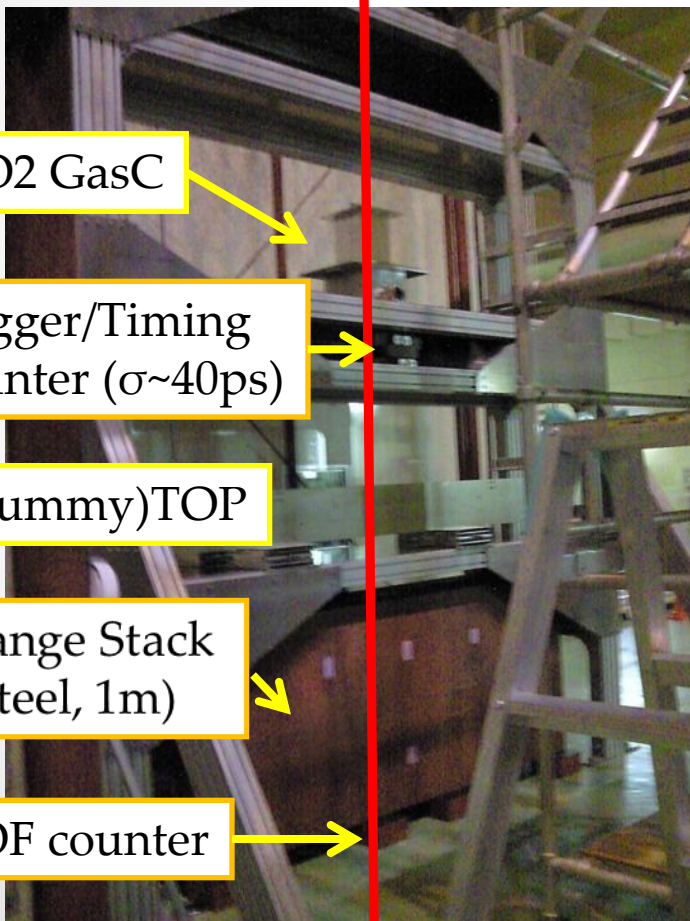
Access Window/Hatch



- PMT modules/Readout blocks to be assembled from Access Window
 - Clean env. (~class 1,000) needed to install PMT modules (contacting to prism).
 - ➔ Class 1,000 clean booth prepared.
- Access Hatch to replace/(re)install PMT modules / readout blocks (in-situ).
 - The details of the procedures to be tested.

Cosmic Ray Test (CRT)

Cosmic Ray Test stand @ Fuji



CO₂ GasC

Trigger/Timing counter ($\sigma \sim 40\text{ps}$)

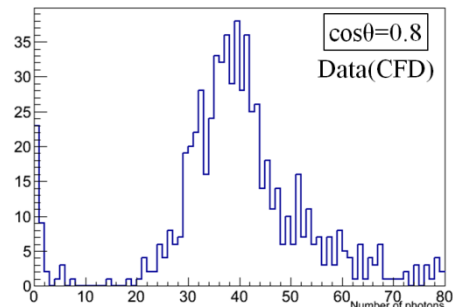
(Dummy)TOP

Range Stack (Steel, 1m)

TOF counter

➤ Cosmic Ray Test stand for the Belle II TOP counters

- ✓ Muon filter ($\beta \sim 0.999$)
➔ GasChe, Range Stack
- ✓ Timing/trigger counter
➔ Belle TOF (custom)
- ✓ Stand
➔ ~2-4 TOP modules



Number of photon hit

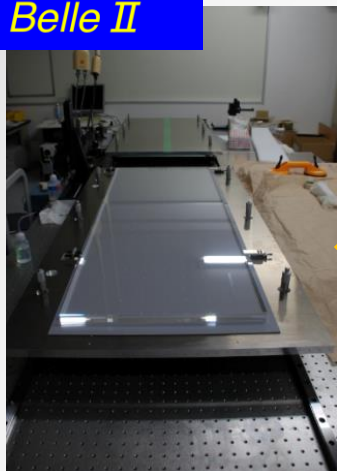
- Upgrade: on-going
 - Muon Tracker
➔ ATLAS Drift Tube
 - Stand, module handling
 - Slow control/monitoring
 - Quartz
 - Gas
 - Cleanliness



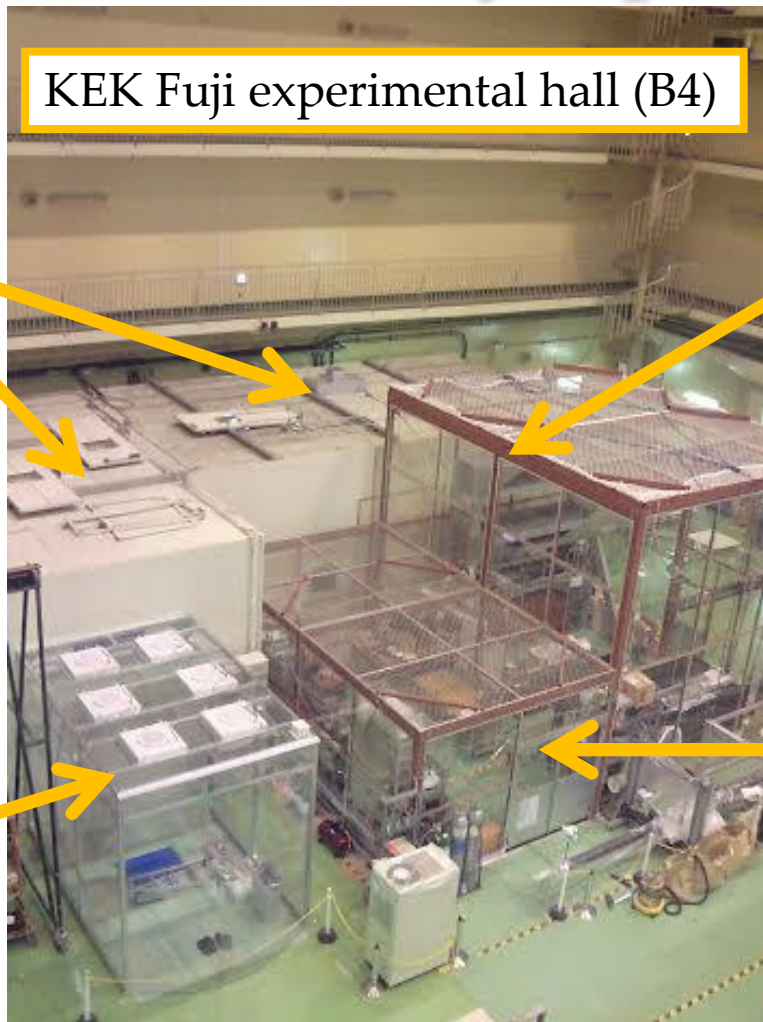
ATLAS Drift Tube

- CRT w/ "IRS" readout will start shortly.

TOP assembly space @ KEK



(1) Class 100-1000 clean room for Quartz



KEK Fuji experimental hall (B4)

(2) PMT assembly Space



(4) Cosmic Ray Test Setup



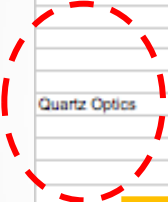
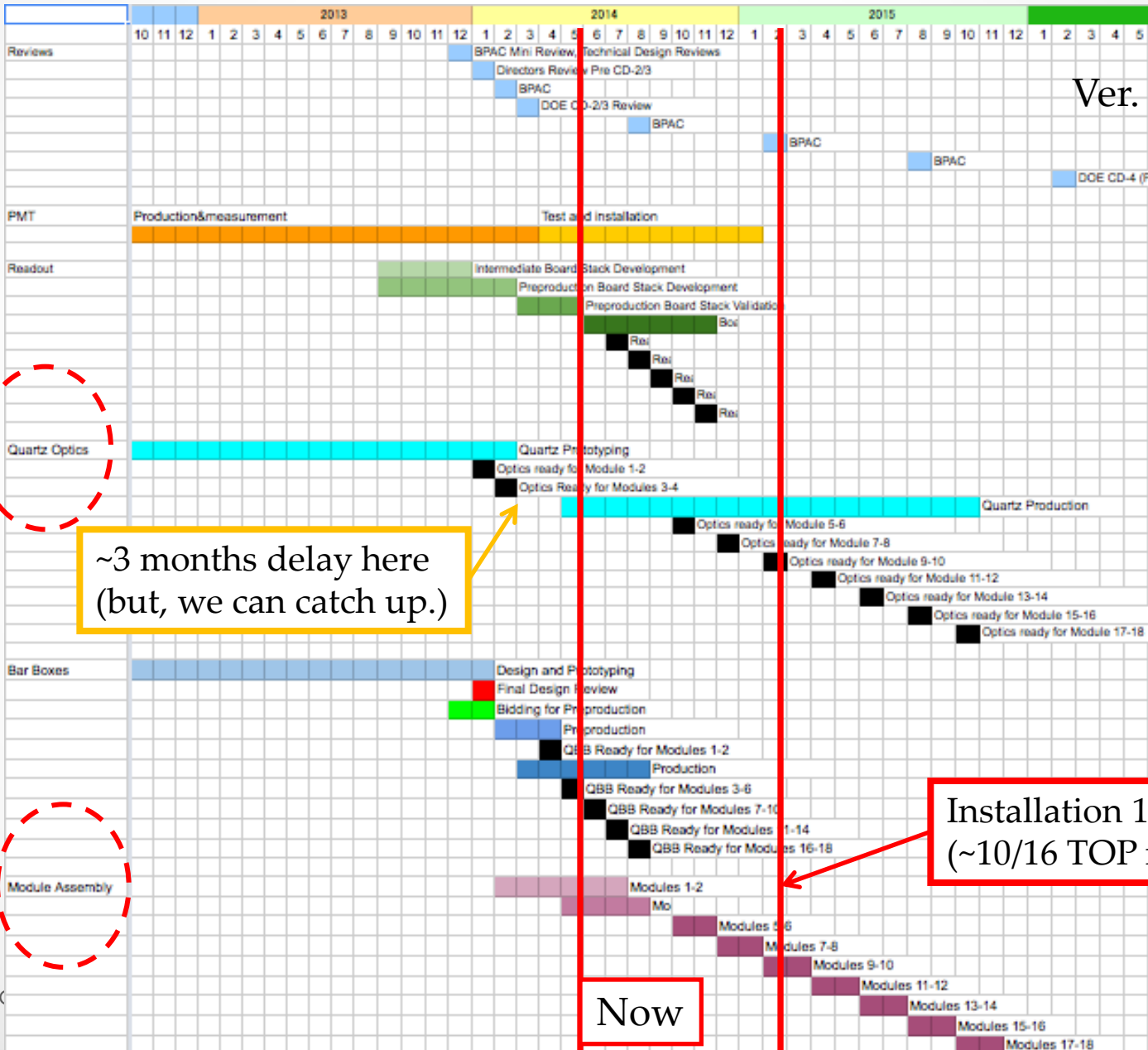
(3) Mechanics / Readout Electronics

1st TOP module assembly is scheduled to start this summer

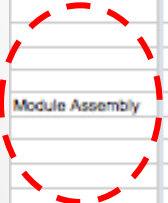


TOP Construction Schedule

Ver. 2013.11.27



~3 months delay here (but, we can catch up.)



Installation 1 (~10/16 TOP modules)

Now



Summary

- 1st full scale prototype of the Belle II TOP counter successfully assembled @ KEK-Fuji.
- Performance of the prototype counter tested using 2GeV/c e⁺ beam at LEPS and cosmic muons at KEK.
 - Several feed-backs have been obtained to the front-end electronics and the opto-mechanical components.
- Production of the MCP-PMTs is going well.
 - Inspection procedure is mostly established.
- Mass production of the quartz optics in progress
 - Acceptance testing: on-going @ KEK and Cincinnati.
 - Procurement schedule still notional.
- Detecotr development / assembly procedures are being finalized.
 - Turning into the construction phase targeting the installation in Feb./Mar. 2015.

backup

...

Complementary to LHCb

Observable	Expected th. accuracy	Expected exp. uncertainty	Facility
CKM matrix			
$ V_{us} [K \rightarrow \pi \ell \nu]$	**	0.1%	<i>K</i> -factory
$ V_{cb} [B \rightarrow X_c \ell \nu]$	**	1%	Belle II
$ V_{ub} [B_d \rightarrow \pi \ell \nu]$	*	4%	Belle II
$\sin(2\phi_1) [c\bar{c}K_S^0]$	***	$8 \cdot 10^{-3}$	Belle II/LHCb
ϕ_2		1.5°	Belle II
ϕ_3	***	3°	LHCb
CPV			
$S(B_s \rightarrow \psi\phi)$	**	0.01	LHCb
$S(B_s \rightarrow \phi\phi)$	**	0.05	LHCb
$S(B_d \rightarrow \phi K)$	***	0.05	Belle II/LHCb
$S(B_d \rightarrow \eta' K)$	***	0.02	Belle II
$S(B_d \rightarrow K^*(\rightarrow K_S^0 \pi^0) \gamma)$	***	0.03	Belle II
$S(B_s \rightarrow \phi \gamma)$	***	0.05	LHCb
$S(B_d \rightarrow \rho \gamma)$		0.15	Belle II
A_{SL}^2	***	0.001	LHCb
A_{SL}^2	***	0.001	LHCb
$A_{CP}(B_d \rightarrow s \gamma)$	*	0.005	Belle II
rare decays			
$\mathcal{B}(B \rightarrow \tau \nu)$	**	3%	Belle II
$\mathcal{B}(B \rightarrow D \tau \nu)$		3%	Belle II
$\mathcal{B}(B_d \rightarrow \mu \nu)$	**	6%	Belle II
$\mathcal{B}(B_s \rightarrow \mu \mu)$	***	10%	LHCb
zero of $A_{FB}(B \rightarrow K^* \mu \mu)$	**	0.05	LHCb
$\mathcal{B}(B \rightarrow K^{(*)} \nu \nu)$	***	30%	Belle II
$\mathcal{B}(B \rightarrow s \gamma)$		4%	Belle II
$\mathcal{B}(B_s \rightarrow \gamma \gamma)$		$0.25 \cdot 10^{-6}$	Belle II (with 5 ab^{-1})
$\mathcal{B}(K \rightarrow \pi \nu \nu)$	**	10%	<i>K</i> -factory
$\mathcal{B}(K \rightarrow e \nu \nu) / \mathcal{B}(K \rightarrow \mu \nu \nu)$	***	0.1%	<i>K</i> -factory
charm and τ			
$\mathcal{B}(\tau \rightarrow \mu \gamma)$	***	$3 \cdot 10^{-9}$	Belle II
$ q/p _{\text{KMI topics}}$	***	0.03	Belle II
$\text{arg}(q/p)_D$	***	1.5°	Belle II

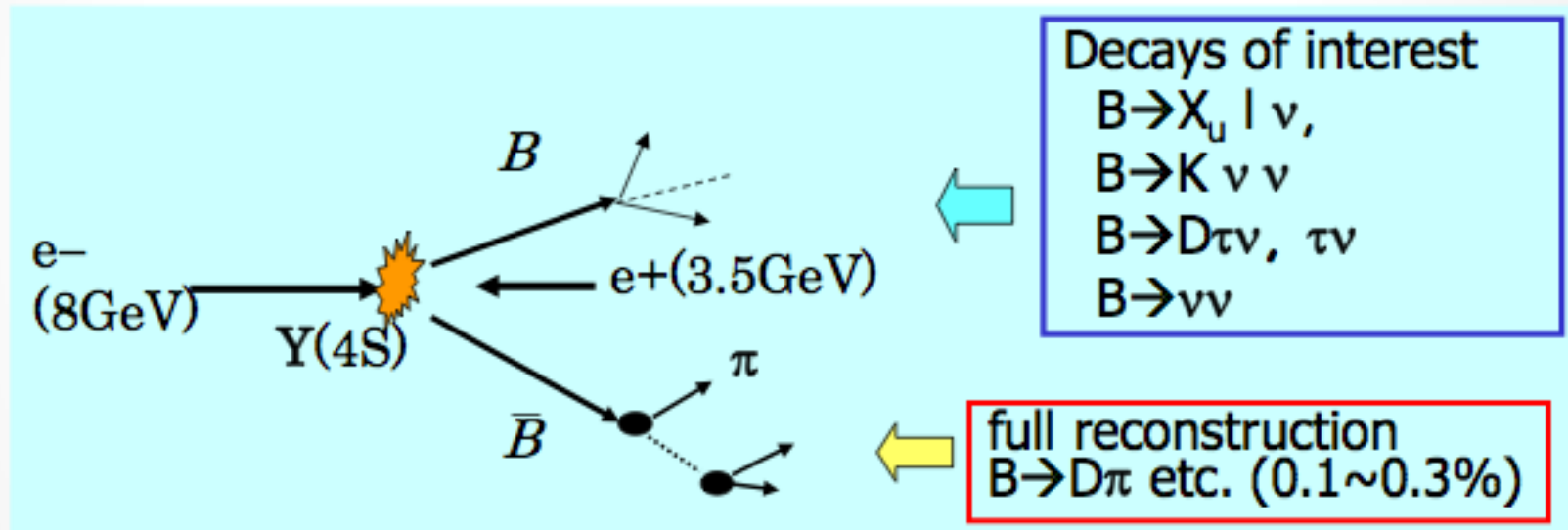
→ Need both **LHCb** and **super B factories** to cover all aspects of precision flavour physics

*adapted from G. Isidori et al.,
Ann. Rev. Nucl. Part. Sci. 60, 355
(2010)*

**B. Golob, KEK FF Workshop,
Feb. 2012**

Power of e^+e^- , example: Full Reconstruction Method

- Fully reconstruct one of the B mesons to
 - Tag B flavor/charge
 - Determine B momentum
 - Exclude decay products of one B from further analysis



→ Offline B meson beam!

Powerful tool for B decays with neutrinos